

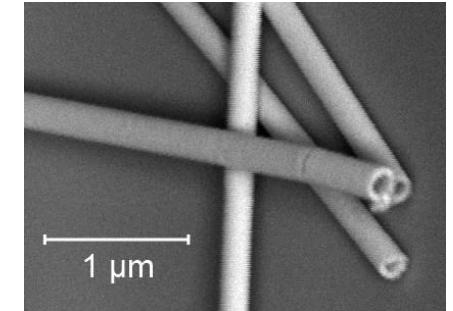
# Fabrication and Characterization of Magnetic Nanowires and Nanotubes



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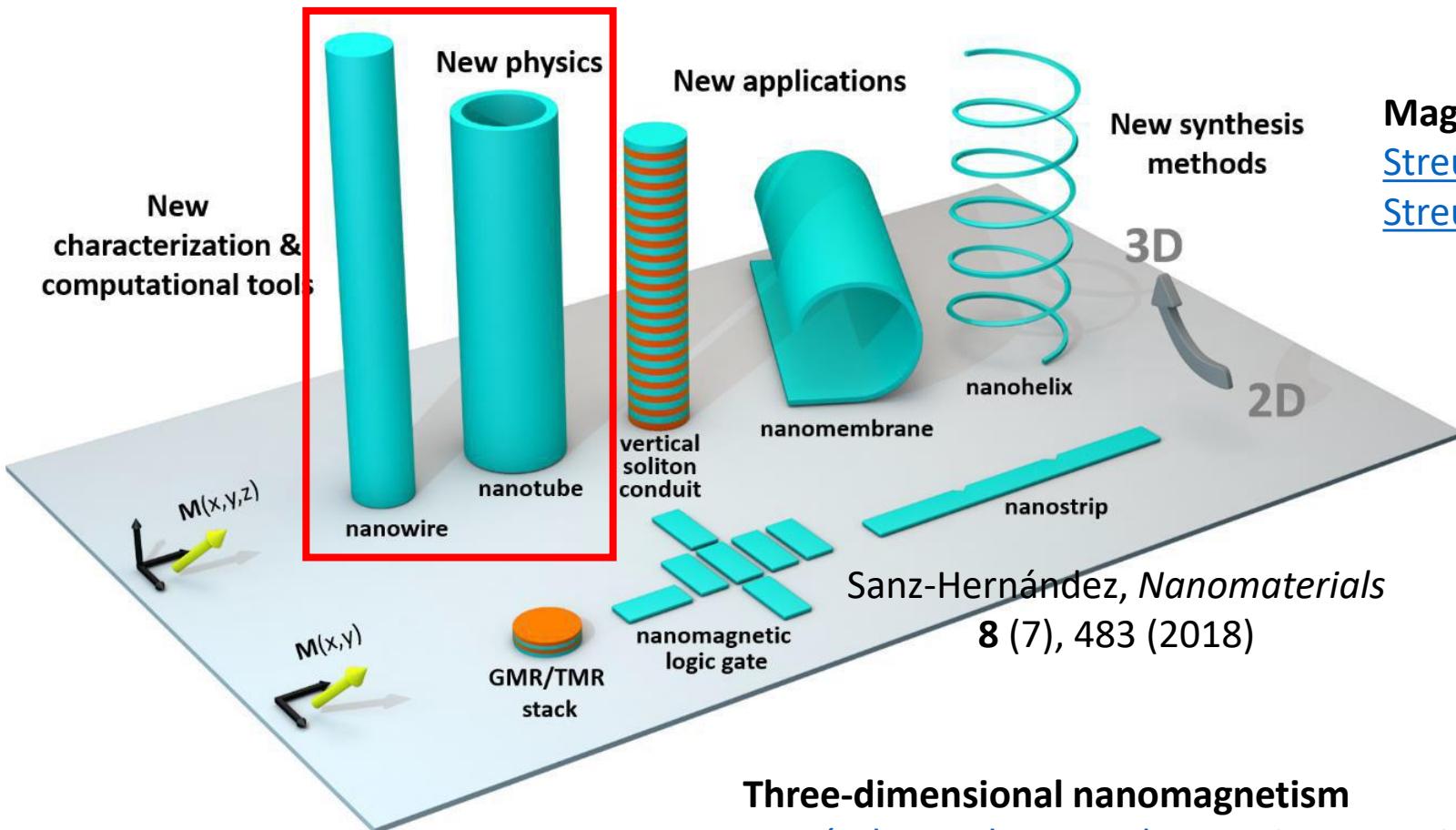


5 June 2025

OPERA COST Action Training School  
Applications and Characterization of Epitaxial Materials



# 3D (curved) magnetic (nano)structures



## Magnetism in curved geometries

[Streubel, J. Appl. Phys. 129, 210902 \(2021\)](#)

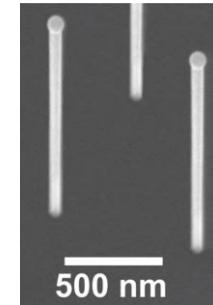
[Streubel, J. Phys. D: Appl. Phys. 49, 363001 \(2016\)](#)

## Magnetic anisotropy

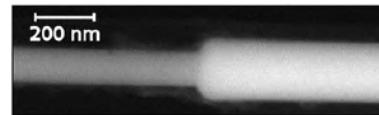
- **Crystal structure (-> epitaxy)**
- **Curvature, shape**
- **Deposition in magnetic field**

# Fabrication of magnetic nanowires (and nanotubes)

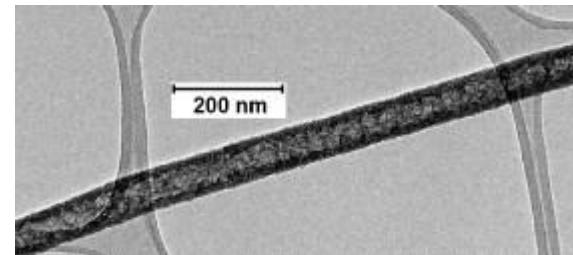
- Nanowires from epitaxial thin films
- Molecular beam epitaxy and other vapour depositions



- Engineered structures, templates



- Chemical methods (using templates)
  - Electroplating
  - Electroless plating
  - Atomic layer deposition



- Bonus content
  - Magnetic characterization of single nanowires/nanotubes
  - Additional information on depositions and templates

# Scope of the presentation

- Overview (non-comprehensive) of nanowire/nanotube fabrication
- Examples given for magnetic materials (metals), the same methods work also for other materials (fabrication often easier for non-magnets)
- Starting with common epitaxy techniques (and single crystal) and focusing on less conventional ones (and eventually nanocrystals)

More details and further reading:

- Vázquez (Ed.), *Magnetic nano-and microwires: design, synthesis, properties and applications (1<sup>st</sup> edition)*, Woodhead Publishing (2015).
- Vázquez (Ed.), *Magnetic nano-and microwires: design, synthesis, properties and applications (2<sup>nd</sup> edition)*, Woodhead Publishing (2020).
- Staňo & Fruchart, *Magnetic nanowires and nanotubes*, in *Handbook of magnetic materials* (Vol. 27, pp. 155-267), Elsevier (2018). Also on [arXiv](#).
- Links to other talks of the school (common epitaxy techniques, X-Ray diffraction, ...)

# Epitaxy

- crystalline layer formed with **well-defined crystal orientation(s)** with respect to the substrate (seed layer); ideally single-crystal
- homoepitaxy – overlayer and substrate from the same material
- heteroepitaxy – different materials, with a small lattice mismatch (strain)

Classic: Same crystal structure,  
similar lattice constant

## Domain matching epitaxy

Matching integer multiples of lattice constants

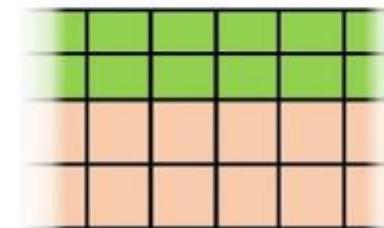
[Narayan & Larson, J. Appl. Phys. 93, 278–285 \(2003\)](#)

## Different crystal structure

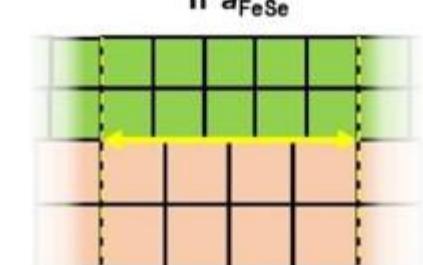
e.g., Nonisostructural complex oxide heteroepitaxy

[Wong & Ramanathan, J. Vac. Sci. Technol. A 32, 040801 \(2014\)](#)

lattice-matching  
epitaxy

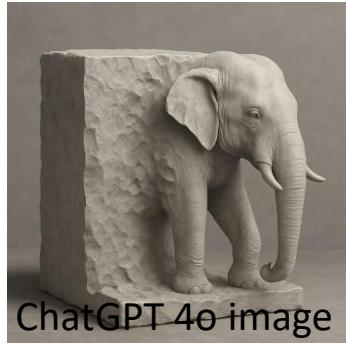


domain-matching  
epitaxy (DME)



Obata, *ACS Appl. Mater. Interfaces* **13**, 53162–53170 (2021)

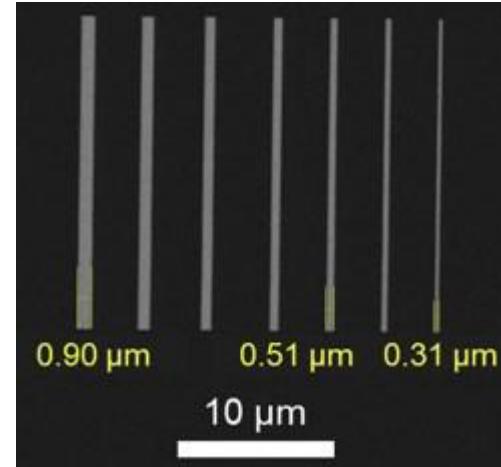
# How to make an ~~elephant~~ sculpture nanowire?



Top-down elephant

How to make an elephant sculpture?

Start with a block and chip away everything that does not look like an elephant!



**How to make a nanowire?**

Start with a block (film) and...



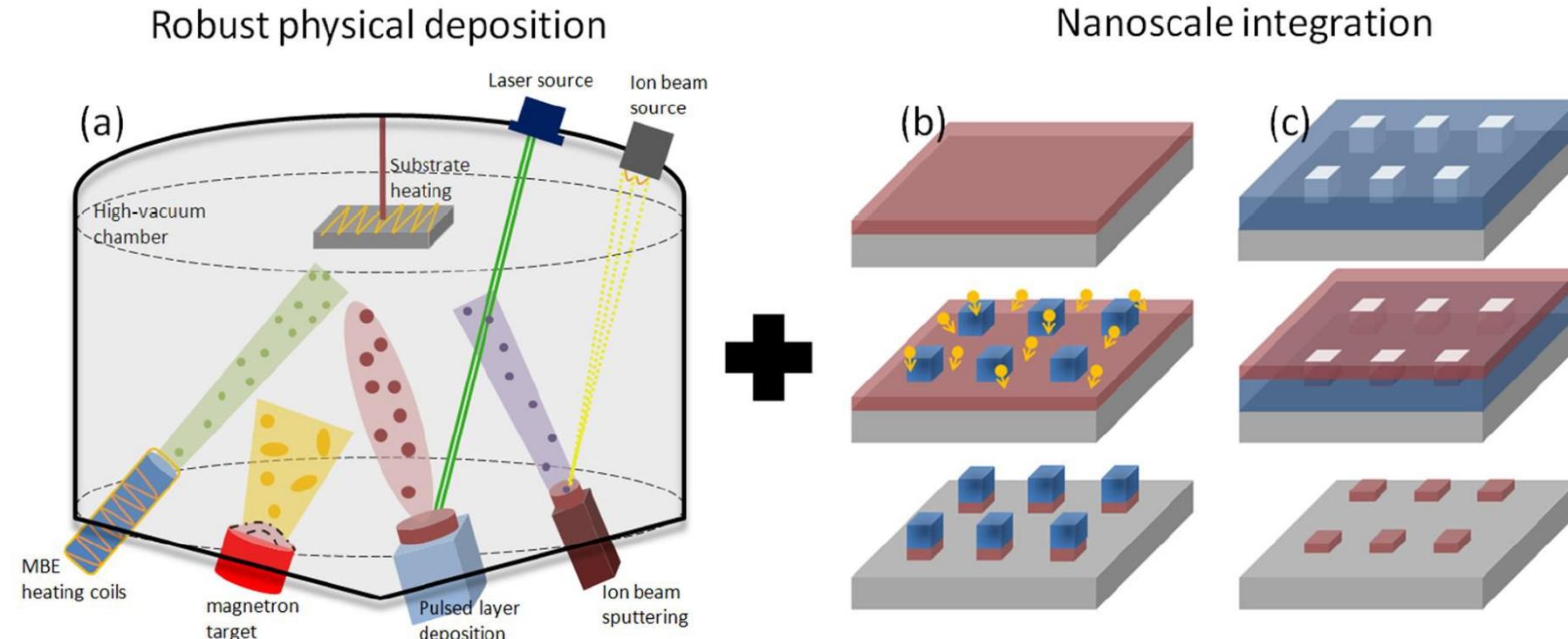
epitaxial thin film → thin film + mask → ion etching → mask removal

**pulsed laser deposition,  
molecular beam epitaxy,  
magnetron sputtering, ...**

+ patterning by lithography  
(top-down approach)

- + Control over position and geometry, but rather 2D
- + Reproducible
- \* Time, resource demanding for large arrays
- \* Patterning can damage / influence structures
- Not well-suited for vertical, high-aspect-ratio structures
- Challenging for smaller wire diameters & high-density, difficult for nanotubes

# Lithography (patterning) of epitaxial films

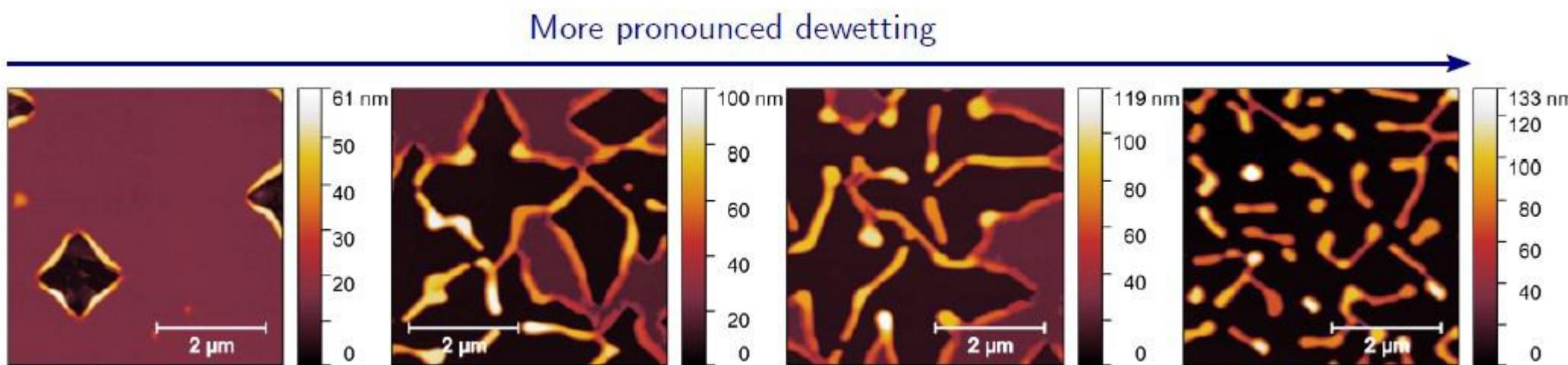
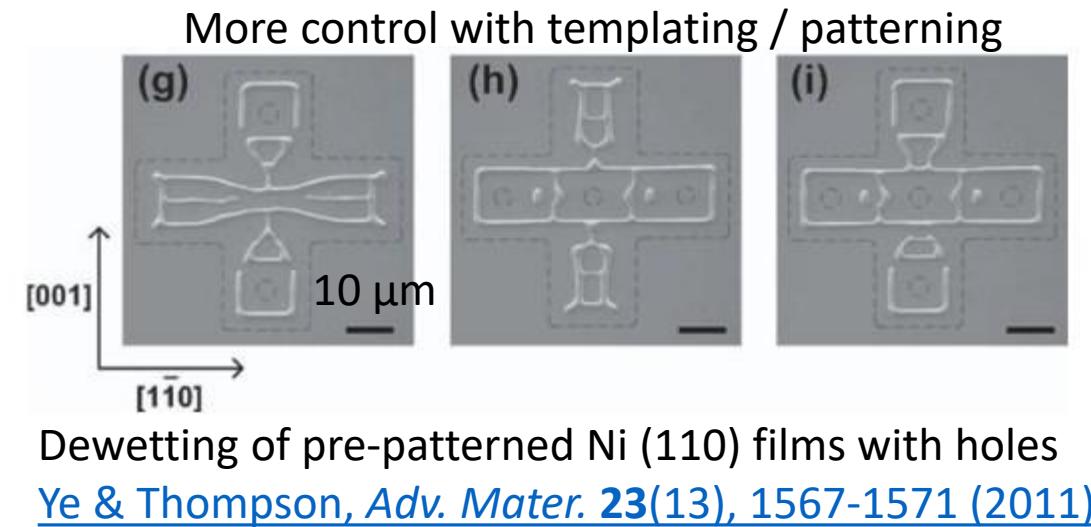
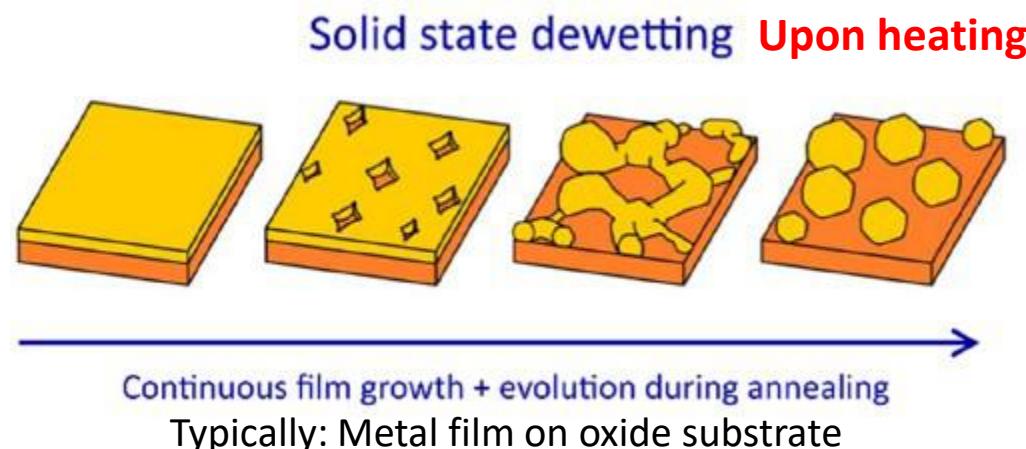


Review - Epitaxial patterning of thin-films

[Zhang, J. Micromech. Microeng. 24, 093001 \(2014\)](#)

- (a) Thin film deposition via physical deposition techniques
- (b) Deposition → lithography → ion etching
- (c) lithography → deposition → lift-off

# Nanowires by solid state dewetting of epitaxial films



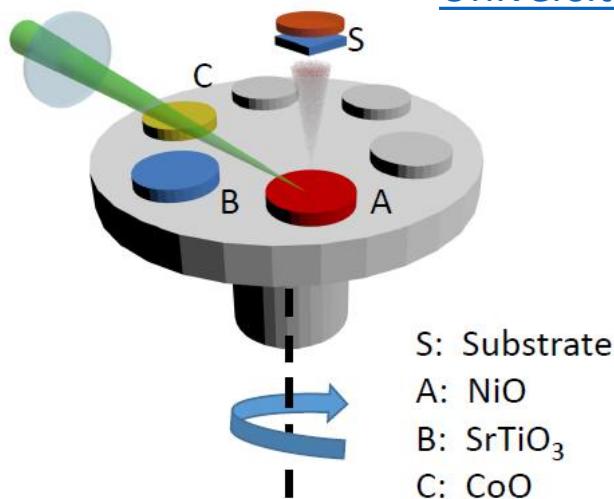
[Motyčková, Magnetic Properties of Self-Assembled FeRh Nanomagnets, Brno University of Technology \(2020\)](#)

# Epitaxial Ni or CoNi NWs in SrTiO<sub>3</sub> matrix

- pulsed laser deposition (PLD) - > see talk by Adam Dubroka
- SrTiO<sub>3</sub> (001) substrate

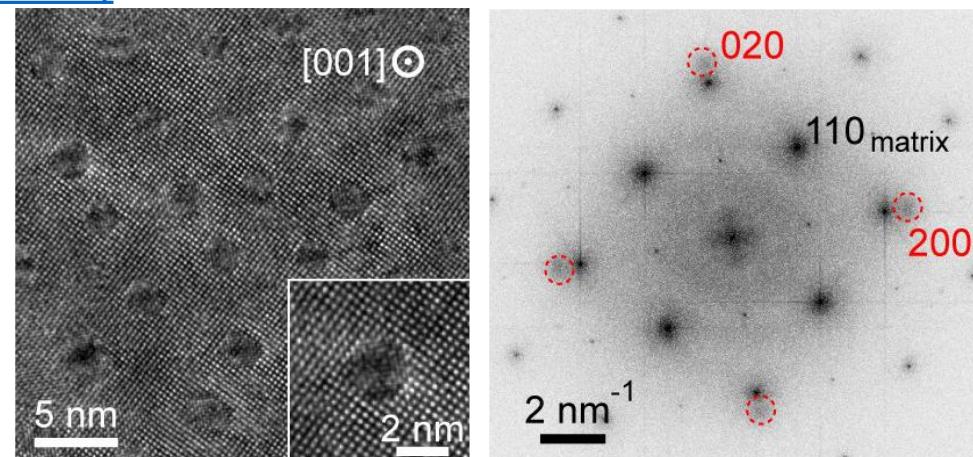
[Weng et al., Phys. Rev. Materials 2, 106003 \(2018\)](#)

[Weng, Epitaxial CoxNi1-x nanowires in SrTiO<sub>3</sub> matrix: growth, structure and control of magnetic anisotropy, Sorbonne Université \(2019\)](#)

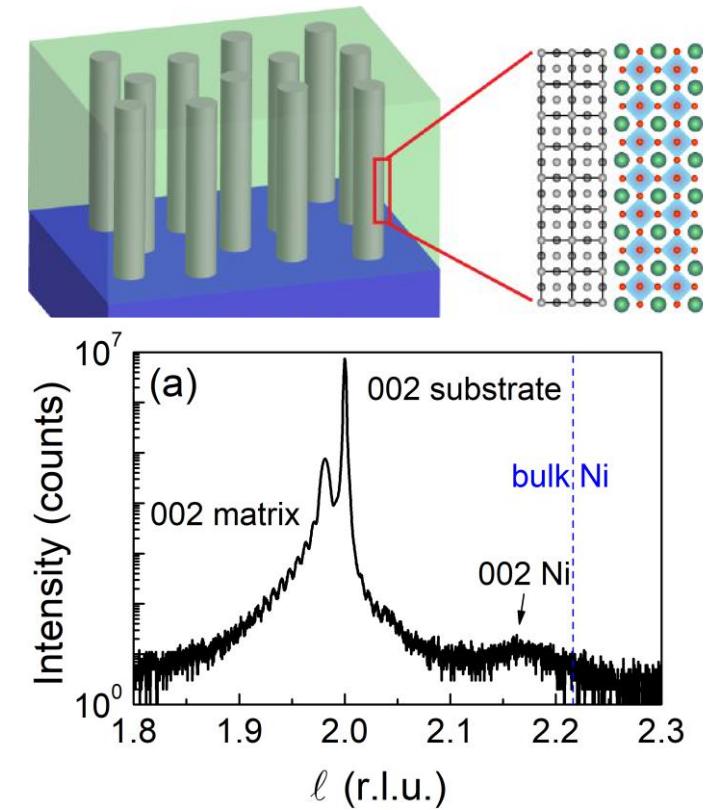
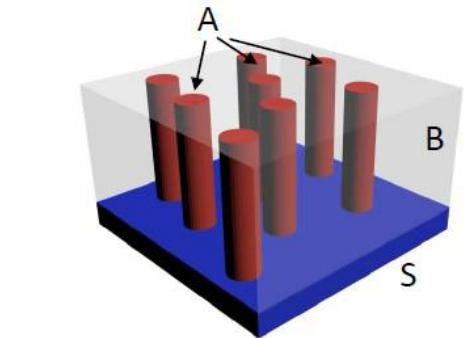


S: Substrate  
A: NiO  
B: SrTiO<sub>3</sub>  
C: CoO

Pulsed Laser Deposition



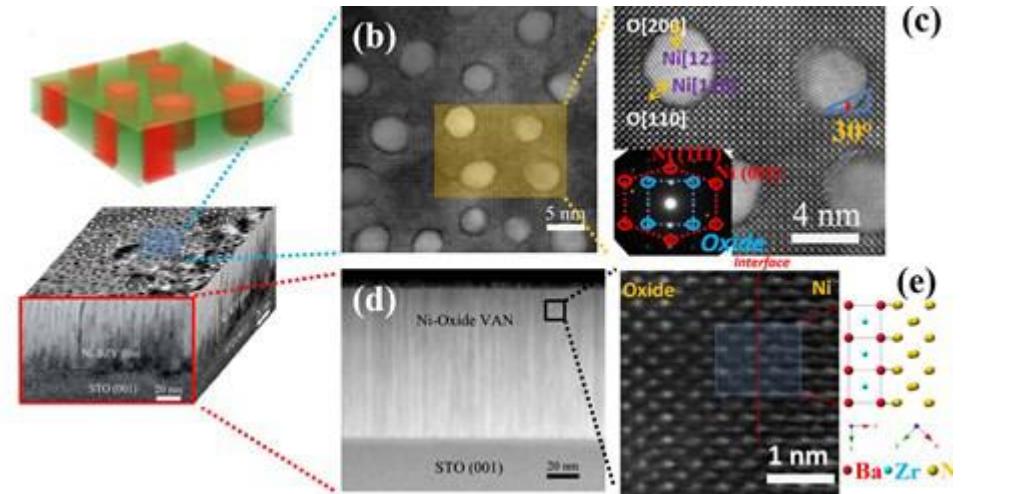
Transmission electron microscopy



X-Ray Diffraction (0-2θ scan)  
See talk by Ondřej Caha

# Vertically aligned nanocomposites

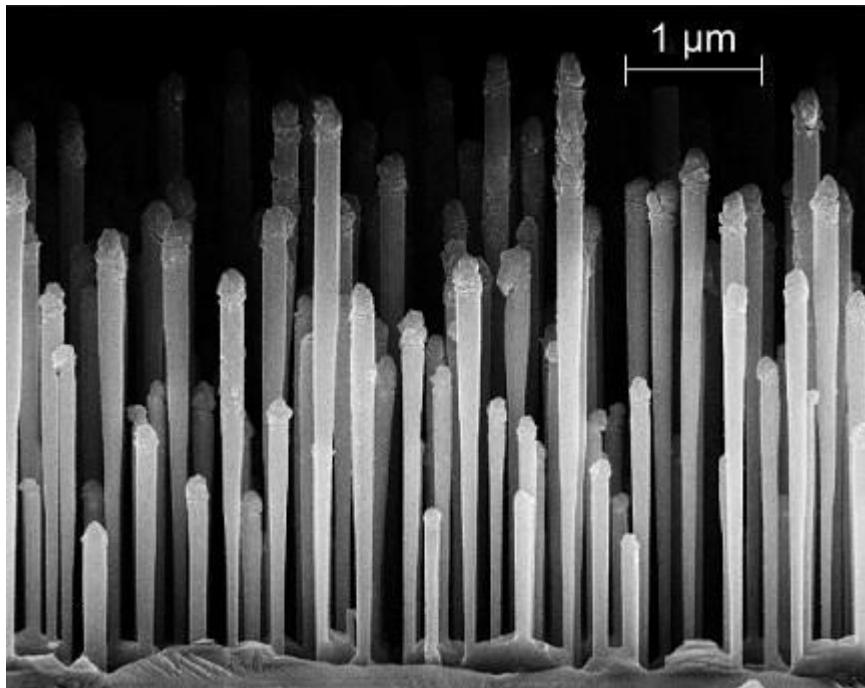
- metal nanopillars embedded in an oxide matrix
  - Co nanowires in CeO<sub>2</sub> film on SrTiO<sub>3</sub>
  - Fe nanowires in BaTiO<sub>3</sub> film on SrTiO<sub>3</sub>
- epitaxial growth of materials with large lattice mismatch
- review: [Misra & Wang, Mater. Horiz. 8, 869-884 \(2021\)](#)
- typical diameter – several nm, length up to 100-200 nm
- formation driven by a combination of strain and surface energy minimization



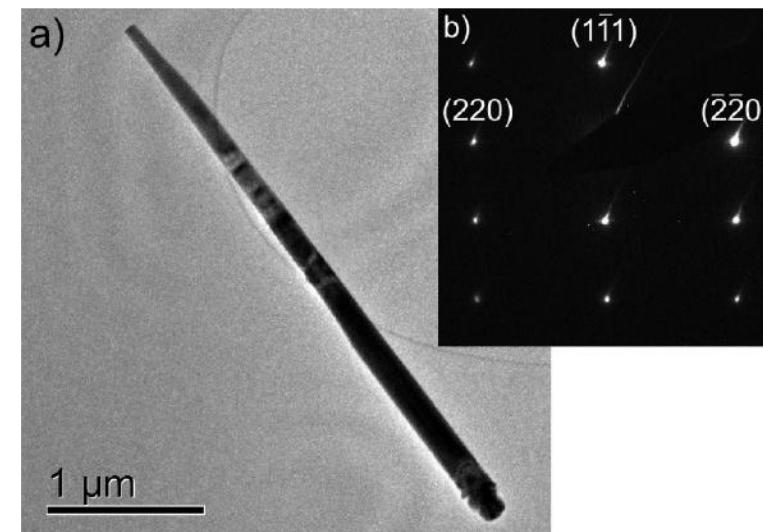
[Su et al., ACS Appl. Mater. Interfaces 8, 31, 20283–20291 \(2016\)](#)

# Molecular Beam Epitaxy

- Molecular Beam Epitaxy – talk by Eduard Hulicius



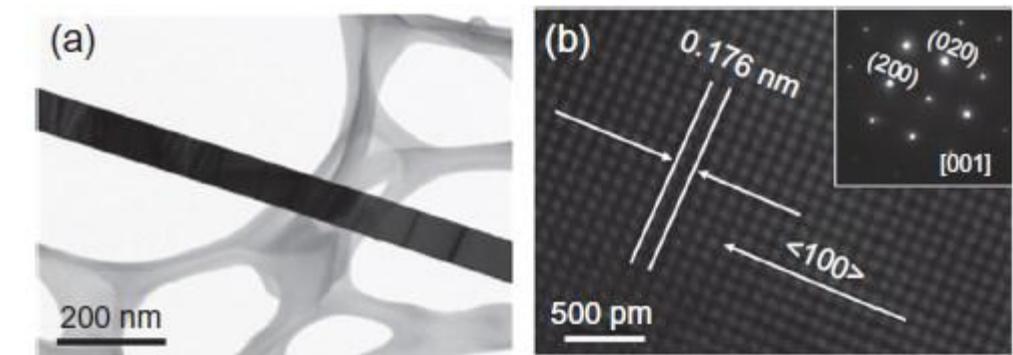
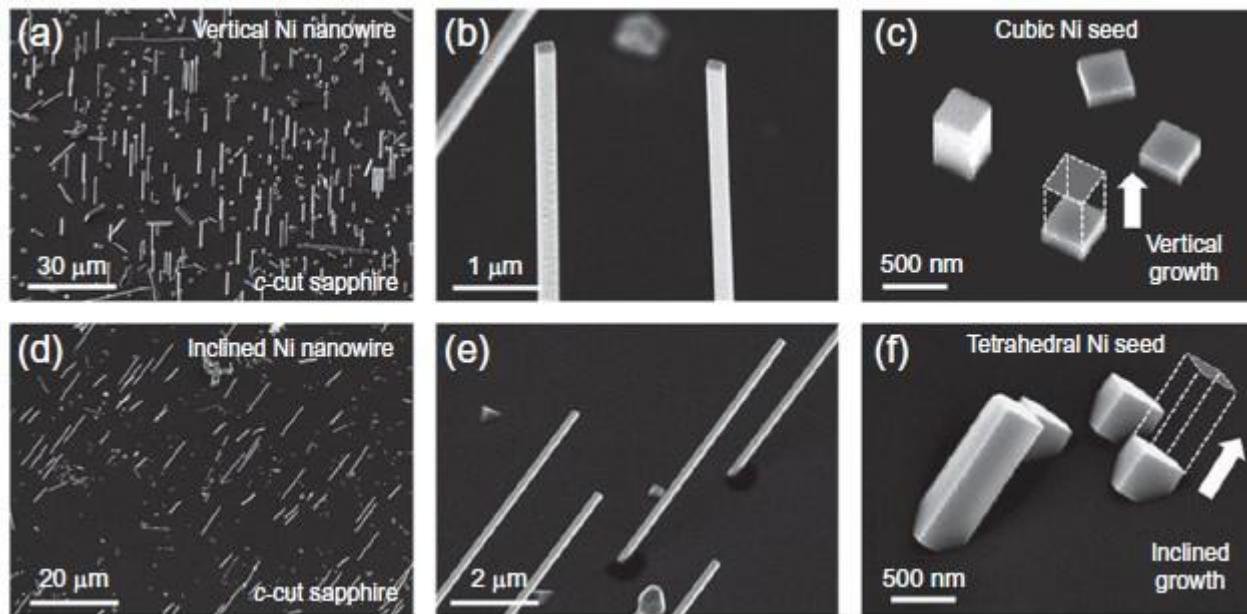
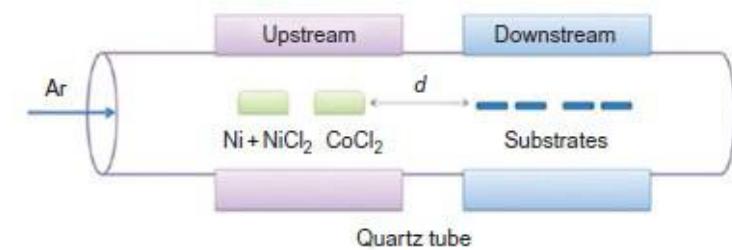
GaMnAs/GaAs core-shell nanowires  
Magnetic only below 30K



Transmission electron microscopy + diffraction  
[Rudolp, \*Nano Lett.\* \*\*9\*\*, 11, 3860–3866 \(2009\)](https://doi.org/10.1021/nl803630s)

# Epitaxial growth of magnetic nanowires by chemical vapor transport

Ni(001) on c-Al<sub>2</sub>O<sub>3</sub> (0001); inefficient control over geometry (diameter >100 nm); also NiCo

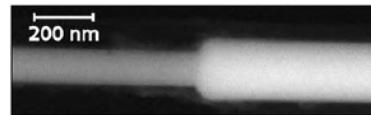


Transmission electron microscopy + diffraction

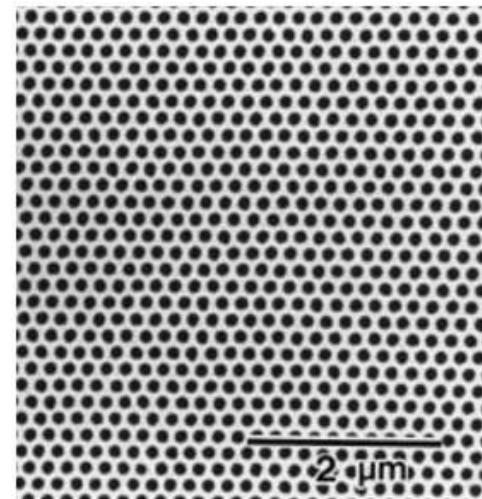
# Fabrication of magnetic nanowires (and nanotubes)

- Nanowires from epitaxial thin films
- Molecular beam epitaxy and other vapour depositions

- **Engineered structures, templates**



- Chemical methods (using templates)
  - Electroplating
  - Electroless plating
  - Atomic layer deposition



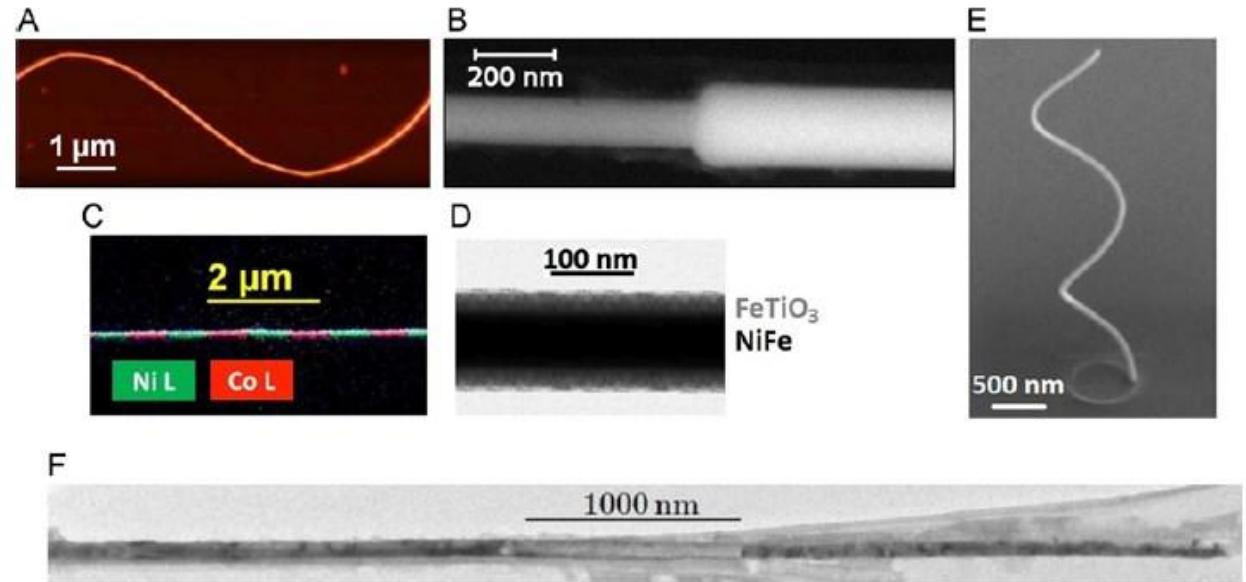
# Simple and engineered structures

## Nanowires (similar for tubes)

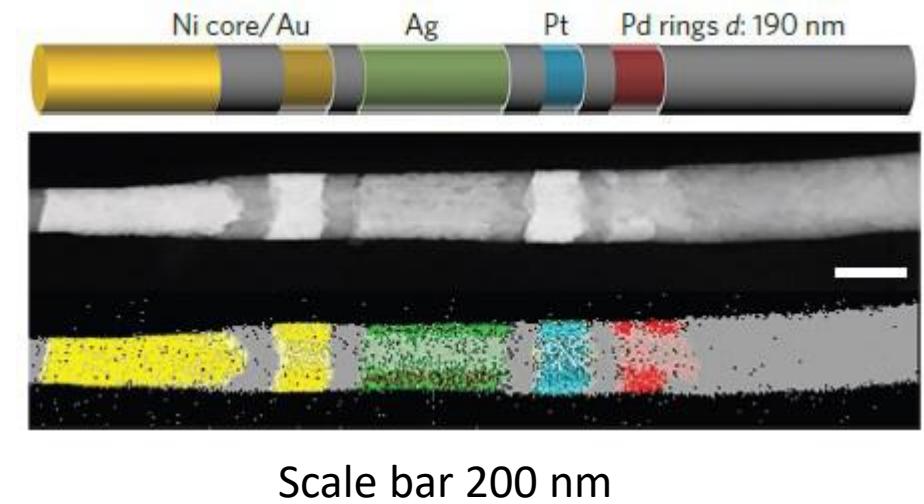
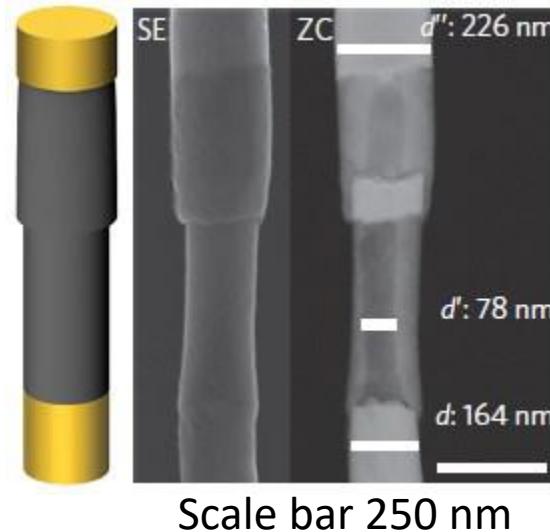
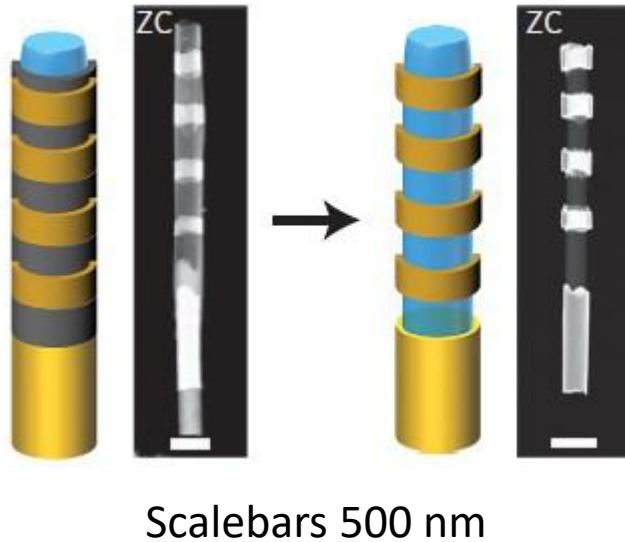
- simple (+bent and 3D helix)
- segmented
- modulated diameter
- core-shell (multilayers)
- graded (composition in axial or radial direction)

## Wire-tube elements

Possible to combine all: **Coaxial lithography**



# Coaxial 'lithography' (from liquid solution)

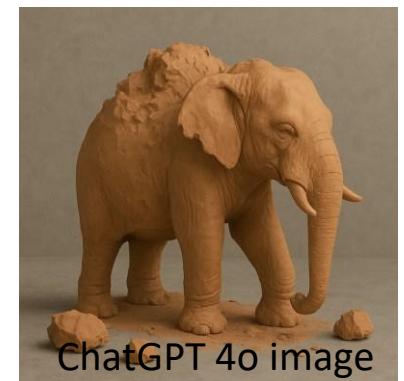


Yellow: Au, Grey: Ni, blue: polymer (polypyrrole or polyaniline)

Combination of chemical methods, selective etching, polymer shrinking, ...

**No epitaxy (so far)**

Ozel et al., *Nat. Nanotechnol.* **10**(4), 319-324 (2015)

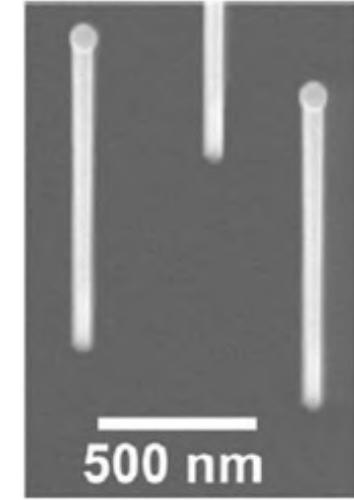
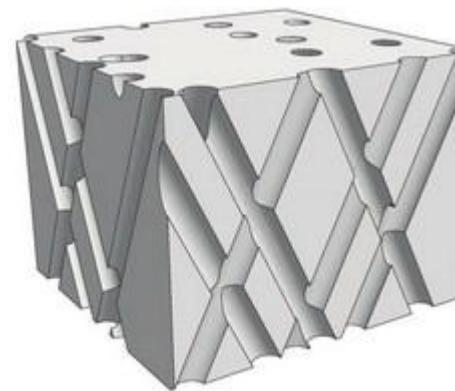
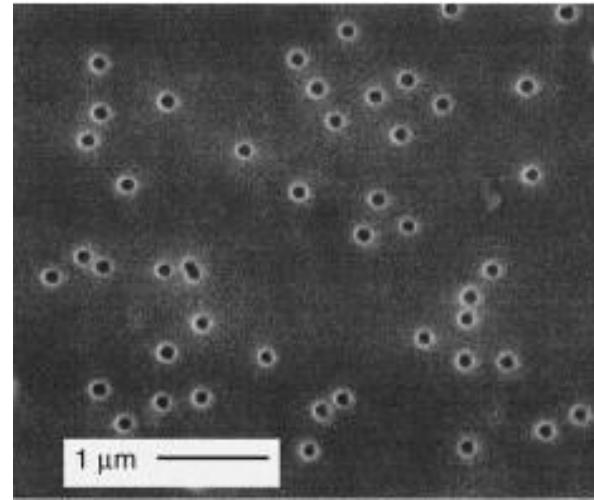
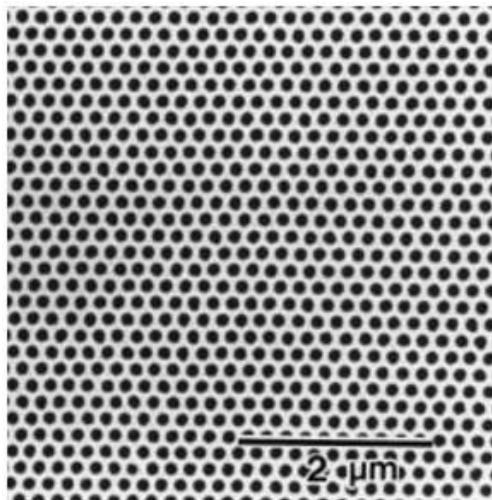


ChatGPT 4o image

Elephant from  
clay pieces

# Templates, scaffolds

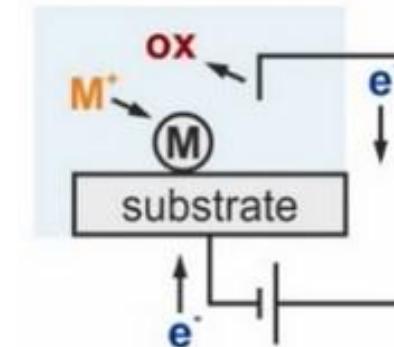
- Aim: Direct and control the growth, obtain desired geometry
- Large scale production, arrays - easier manipulation and measurements
- Option: Dissolve template to release single nanostructures



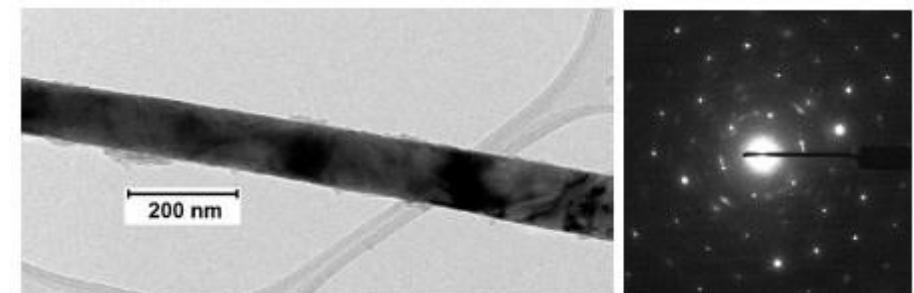
- **Nanoporous templates** – nanoporous anodic alumina, ion-track-etched polycarbonate, complex pores in resist via 2 photon lithography
- For nanotubes: **Arrays of nanowires** (often epitaxial semiconductors)

# Fabrication of magnetic nanowires (and nanotubes)

- Nanowires from epitaxial thin films
- Molecular beam epitaxy and other vapour depositions
- Engineered structures, templates
- **Liquid solution-based depositions (using templates)**
  - Electroplating
  - Electroless plating
- Atomic layer deposition (using templates)

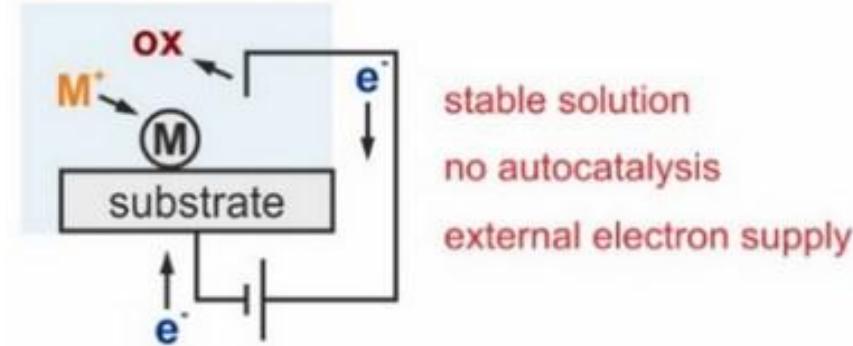


stable solution  
no autocatalysis  
external electron supply



# Electroplating (Electrodeposition)

- Reduction of metal cations at cathode (negative electrode);  $\text{Ni}^{2+} + 2\text{e}^- \rightarrow \text{Ni}$
- **Electrolyte** = ionic conductor (e.g.,  $\text{NiSO}_4$  dissolved in water + additives)
- Materials - electrically conductive metals, semiconductors, conductive polymers
- For nanowires/tubes: spatially restricted nucleation and growth – **nanoporous  $\text{Al}_2\text{O}_3$  template**

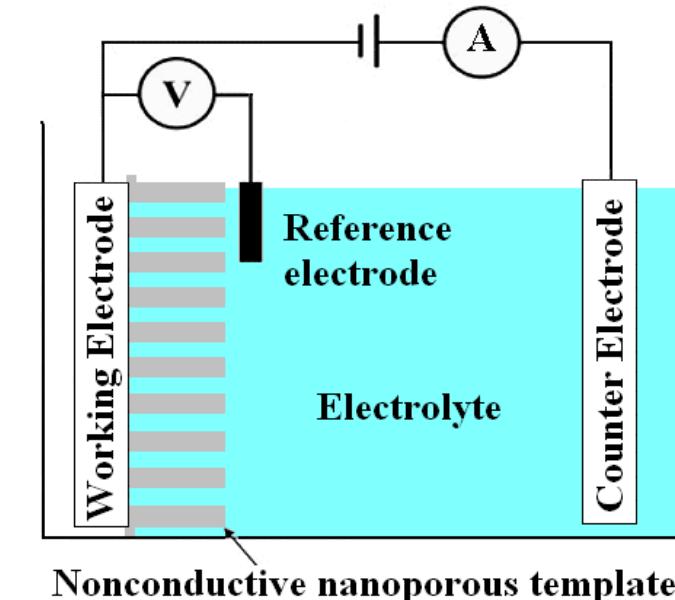


Book: [\*Modern electroplating\* \(5th ed.\), John Wiley & Sons \(2010\)](#)

Epitaxial growth (films, islands) – reviews (mostly non-magnetic):

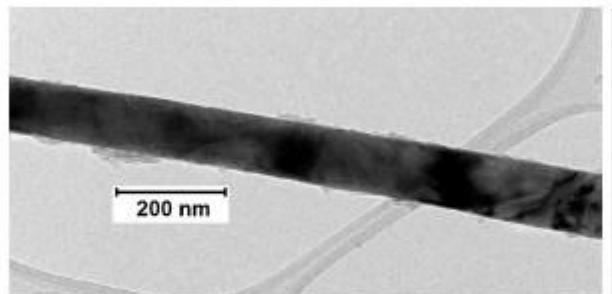
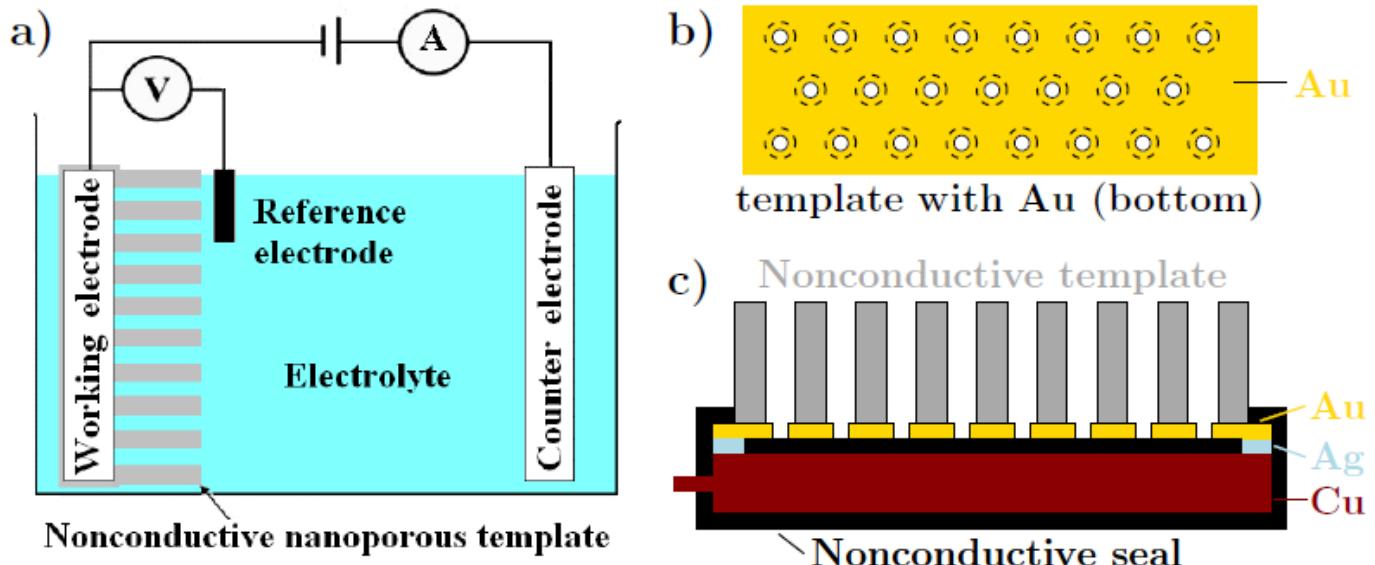
[Switzer & Banik, Acc. Chem. Res. 56\(13\), 1710-1719 \(2023\)](#)

[Guo, Nano Trends 4, 100024 \(2023\)](#) – some works only textured deposits or preferred crystal orientation

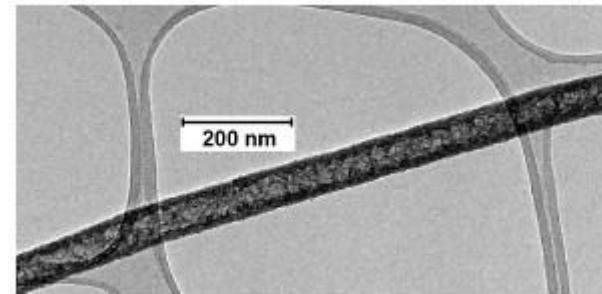
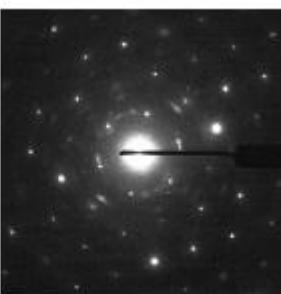


# Electroplating - How to get nanotubes instead of solid nanowires

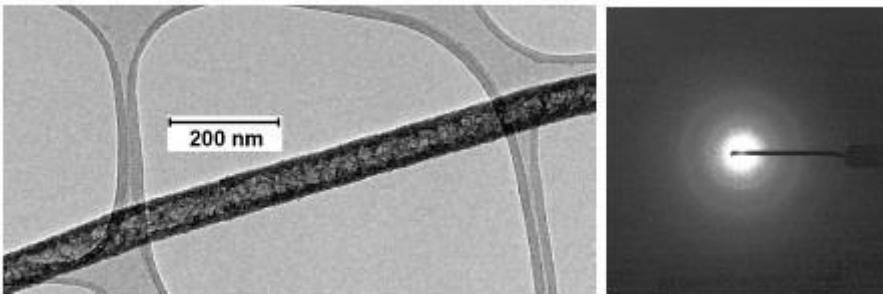
- porous working electrode
- low pH (acidic solution)
- more negative potential
- lower concentration of metal ions



(a) Nanowire (diameter  $\approx$  100 nm)

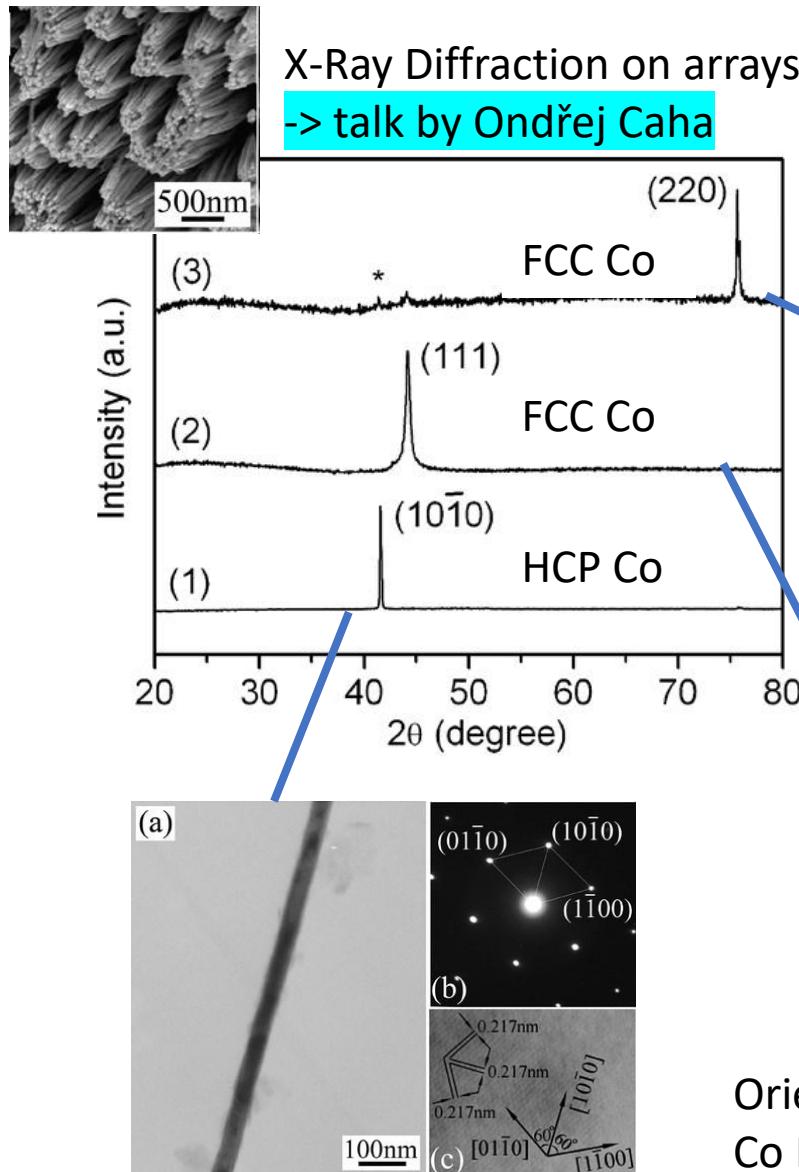


(b) Nanotube (diameter  $\approx$  70 nm, tube wall 10-18 nm)

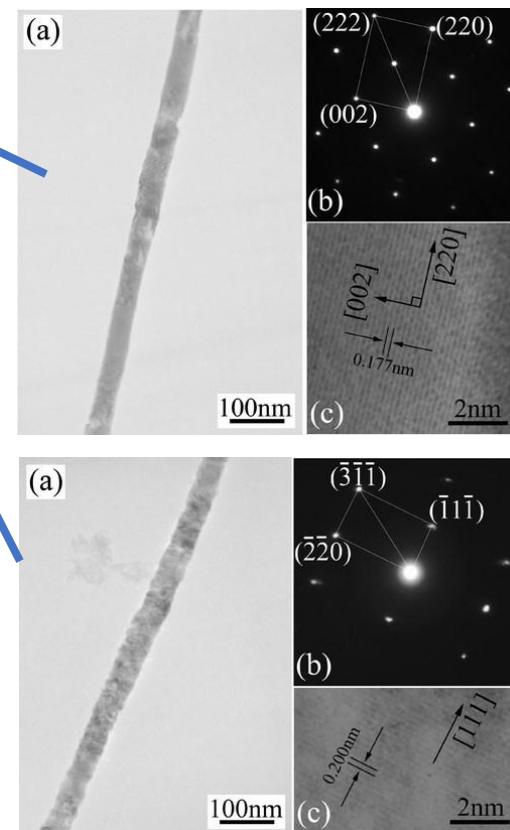


**Electroplated NiCo nanostructures:** (a) nanowire, (b) nanotube. Transmission electron microscopy + selected area electron diffraction (Laurent Cagnon, Institut Néel).

# Electroplating - Crystal Control (Co example)



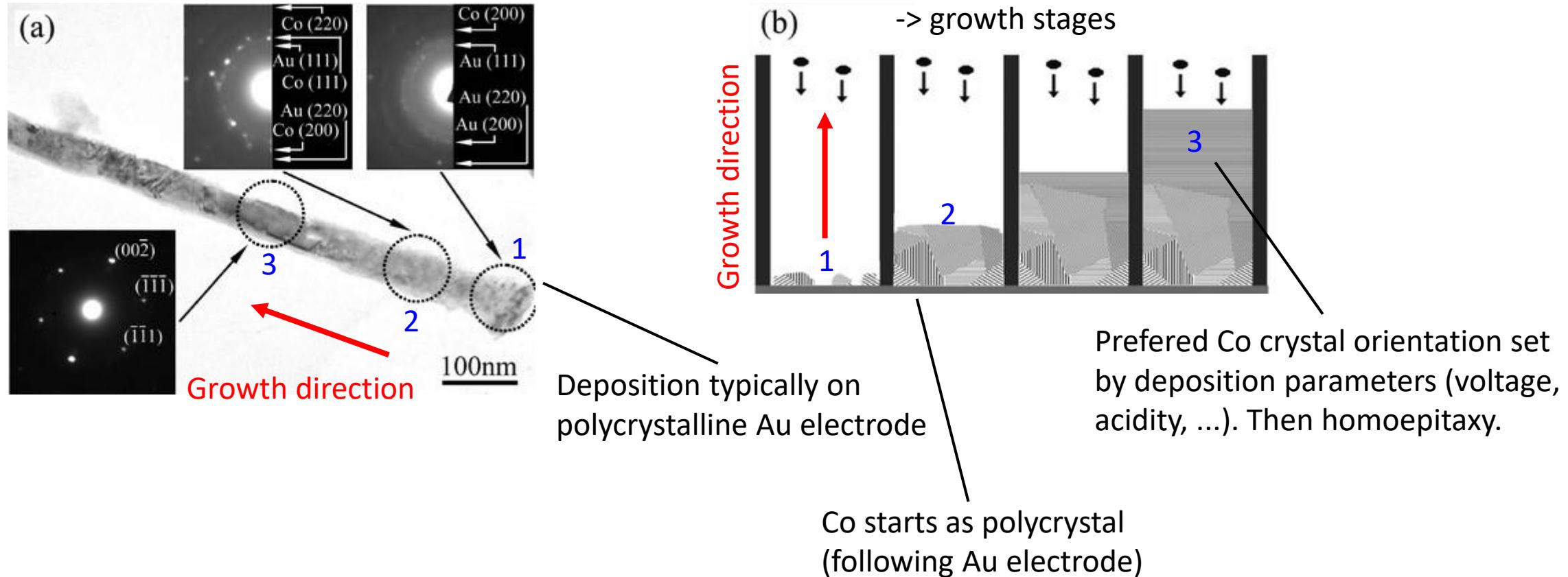
**Co Nanowires,  
40 nm diameter**



**Same template, different  
deposition conditions  
(voltage pulses and acidity)**

Orientation-Controlled Synthesis and Ferromagnetism of Single Crystalline Co Nanowire Arrays, [Huang, J. Phys. Chem. C 112, 1468-1472 \(2008\)](#)

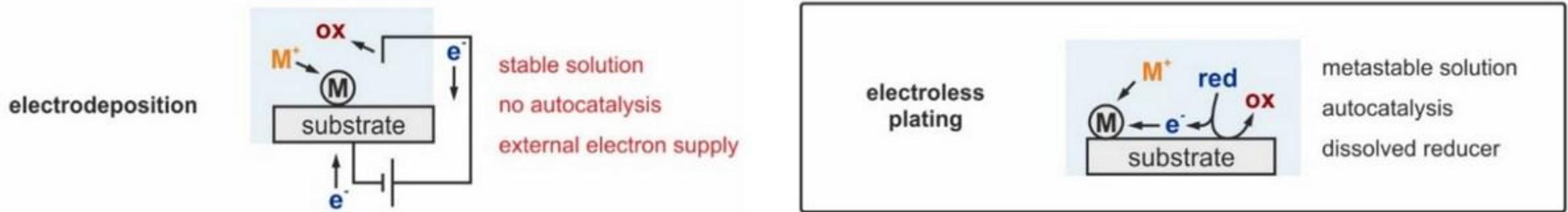
# Electroplating - Crystal Control (Co example)



Orientation-Controlled Synthesis and Ferromagnetism of Single Crystalline Co Nanowire Arrays, [Huang, J. Phys. Chem. C 112, 1468-1472 \(2008\)](https://doi.org/10.1021/j30257001)

# Electroless plating

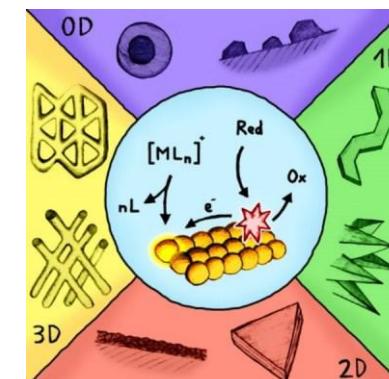
Similar to electroplating – reduction of metal ions from solution



Difference: electrons for reduction from added reducing agent  
(auto)catalysis – reduction only on catalyst seeds or already grown material

Review: Electroless Plating of Metal Nanomaterials

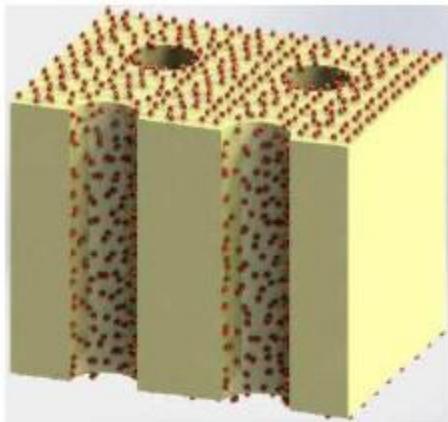
[Muench, ChemElectroChem 8\(16\), 2993-3012 \(2021\)](#)



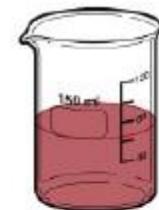
# Electroless plating of nanotubes

Conformal coating of modified walls of porous template

- Surface sensitization ( $\text{SnCl}_2$ ), activation with Pd seeds ( $\text{PdCl}_2$ )
- Selective deposition (metal reduction) on Pd seeds (plating bath)
- Removal of top/bottom layer, template dissolution

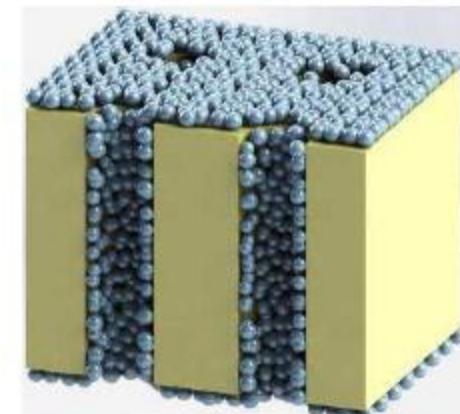
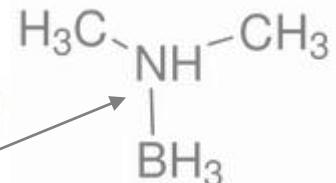


Template with Pd seeds



Plating bath

metal salts ( $\text{CoSO}_4$ ,  $\text{NiSO}_4$ )  
reducing agent (DMAB)  
stabilizing agent (sodium citrate)

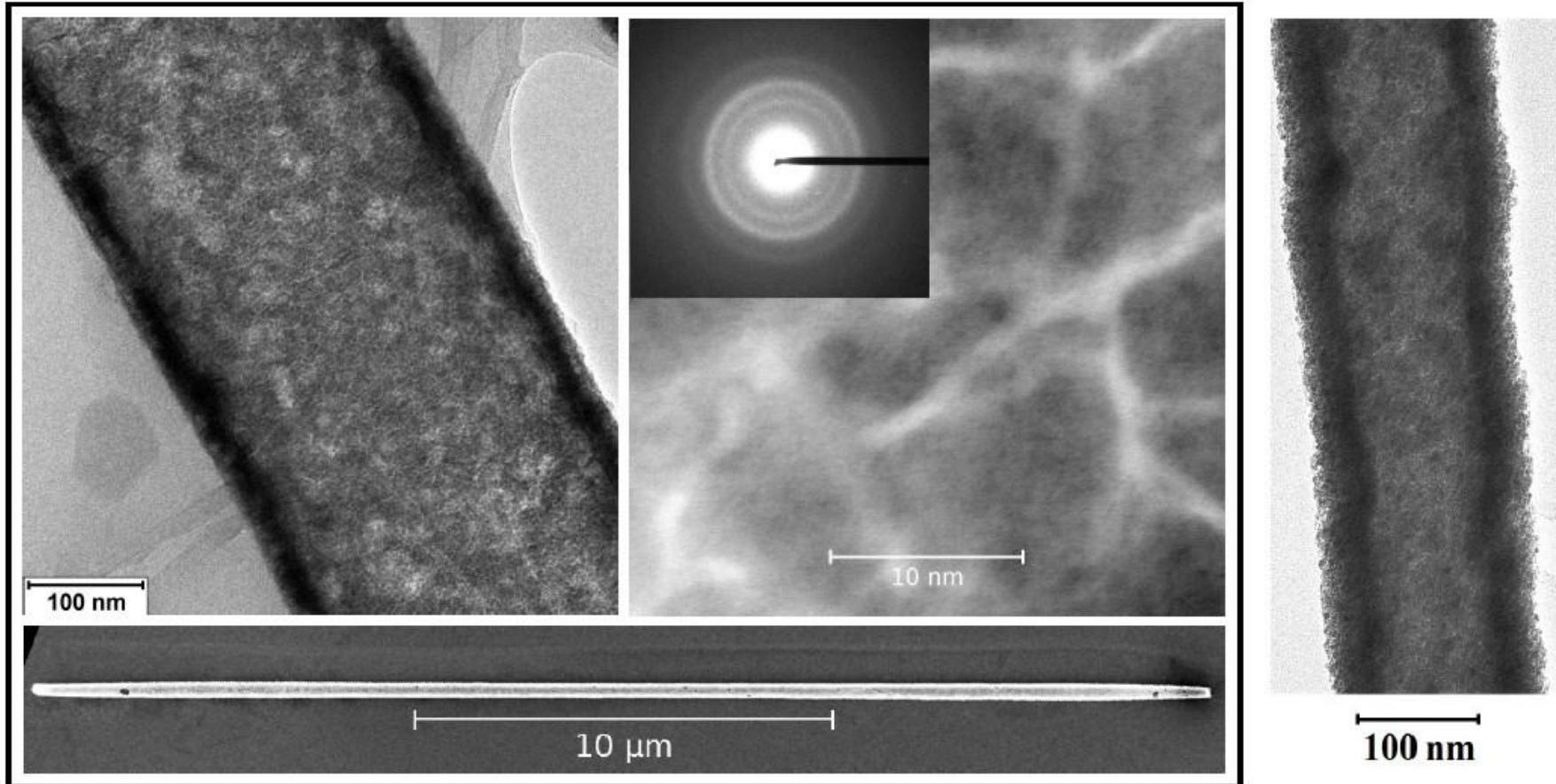


Initial tube growth

Images of templates: Richardson et al., *ECS Trans.* **64** (31), 39-48 (2015)

Deposition of **metals, alloys, oxides**; no need for conductive substrate

# Electroless plating - CoNiB nanotubes (example)

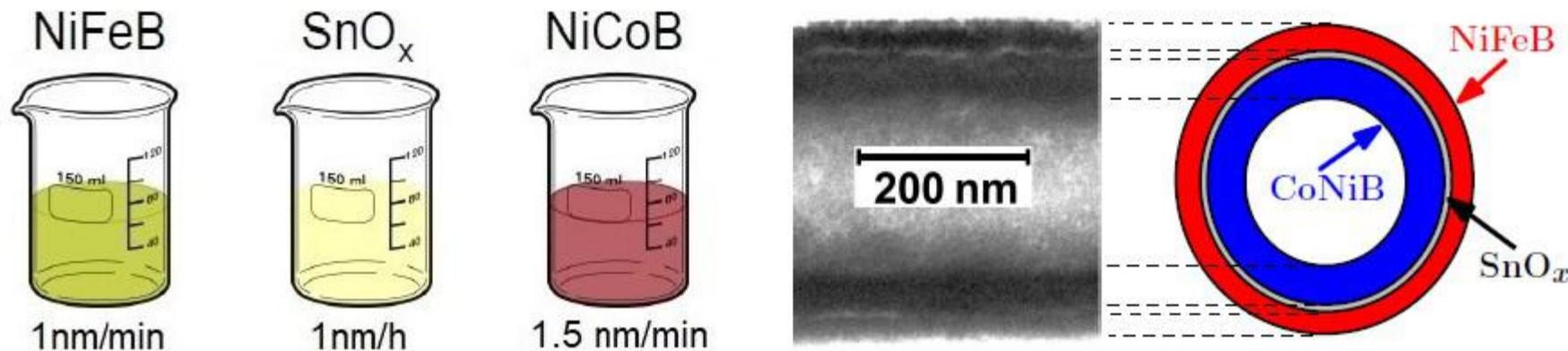


$(\text{Co}_{80}\text{Ni}_{20})\text{B}$  nanocrystalline tubes: [RSC Adv. 6, 70033-70039 \(2016\)](#)  
Diameter 300-400 nm, length 30  $\mu\text{m}$ , wall thickness  $\approx$  30 nm

# Electroless plating - Multilayered nanotubes

Electroless plating of NiFeB/SnO<sub>x</sub>/CoNiB multilayered tubes

SnO<sub>x</sub> - non-magnetic spacer; selected for ease of deposition



Different deposition solutions with layer deposition rates

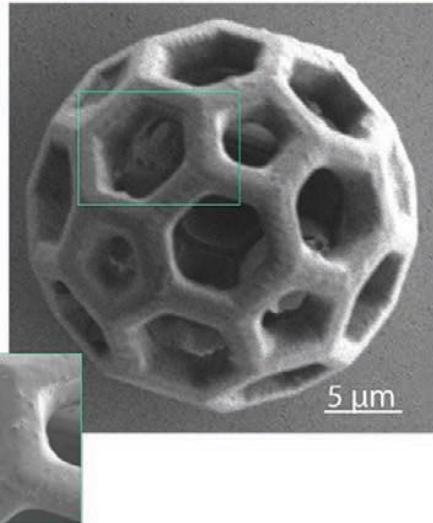
Staňo, Magnetic microscopy of domains and domain walls in ferromagnetic nanotubes, Université Grenoble Alpes (2017)

# Electroless plating – Coating of complex 3D scaffolds

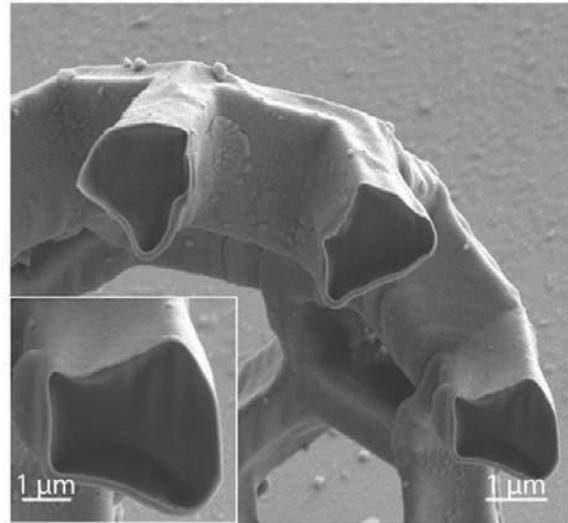
Conformal = covers uneven surfaces, holes, ... nearly everything ☺

3D scaffolds created by two-photon lithography

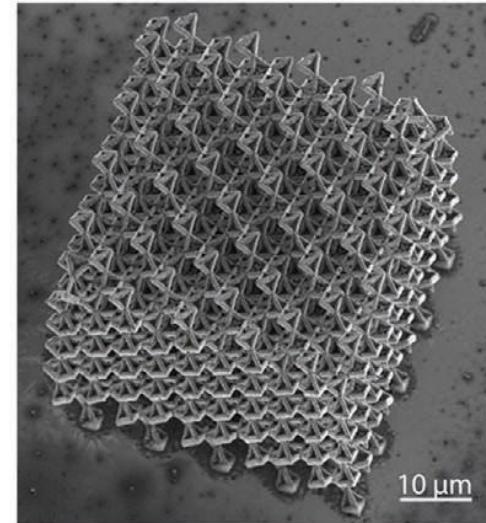
a)



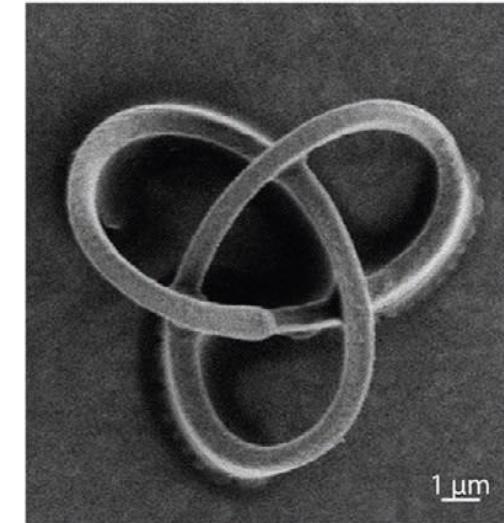
b)



c)



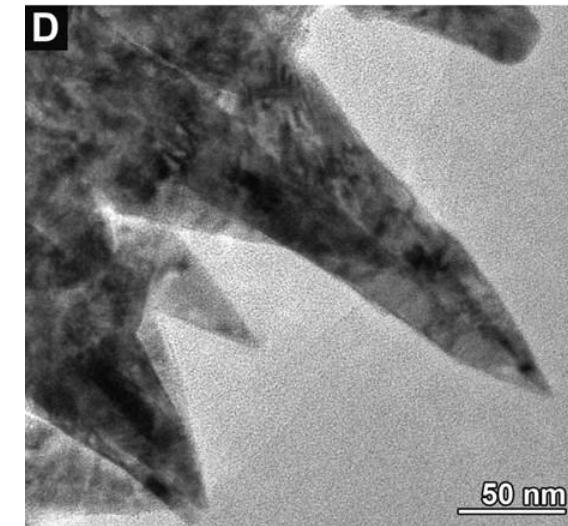
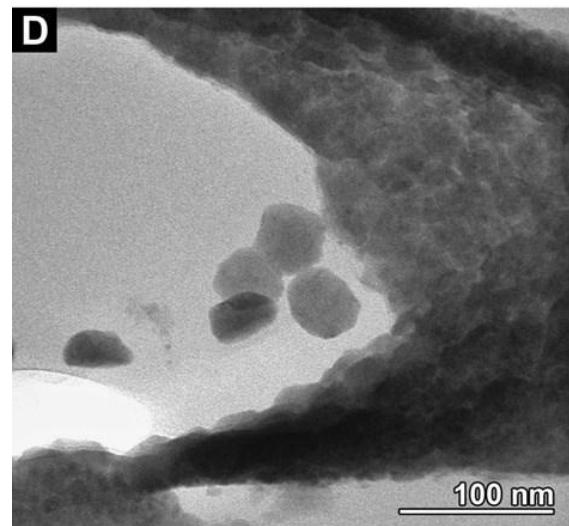
d)



3D polymer structures with magnetic NiFe(B) coating by electroless plating

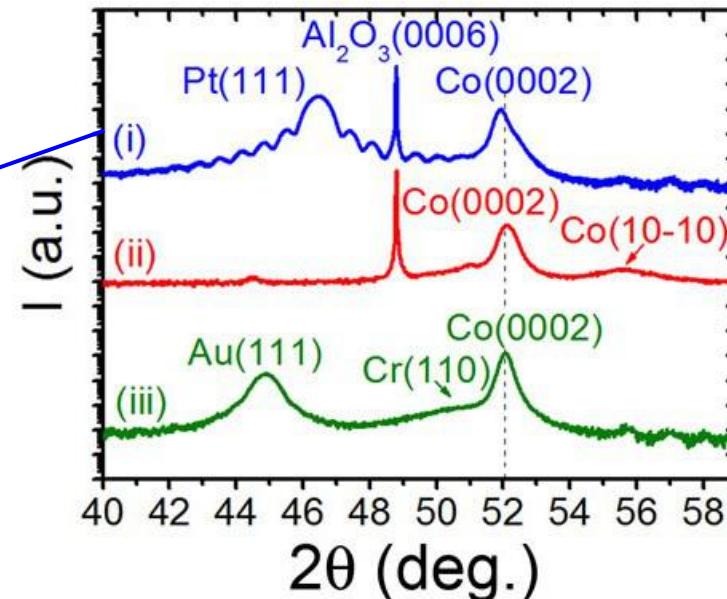
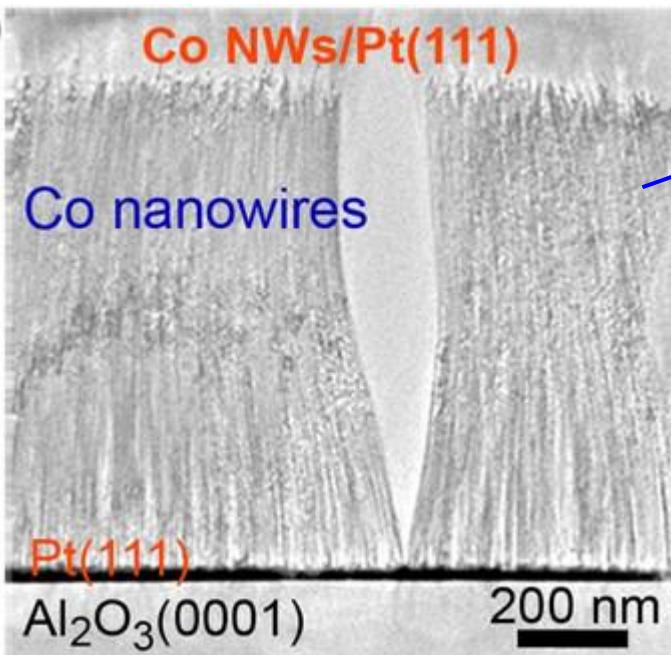
# Crystallinity control via reducing agent

- Reducing agents (chemicals) often contain: Boron, Phosphorus  
These can be incorporated in the deposit
- Larger amount of boron/phosphorus -> amorphous  
Small amount -> (poly)crystalline
- Different agent (no B or P, like hydrazine): crystals, but spiky surface

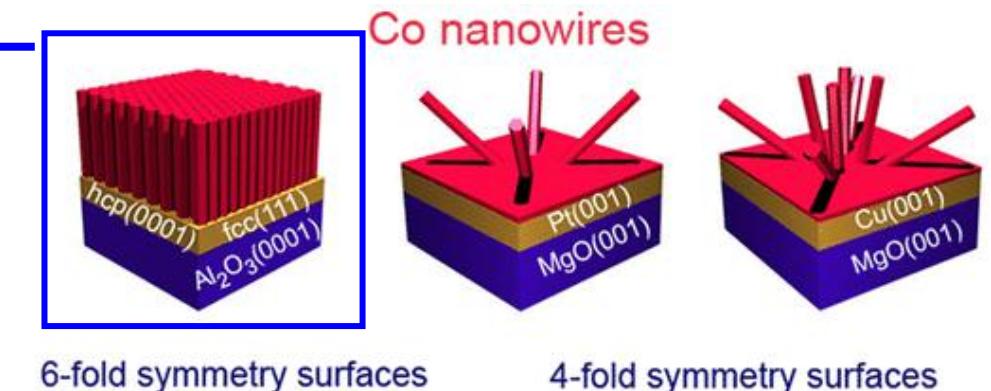
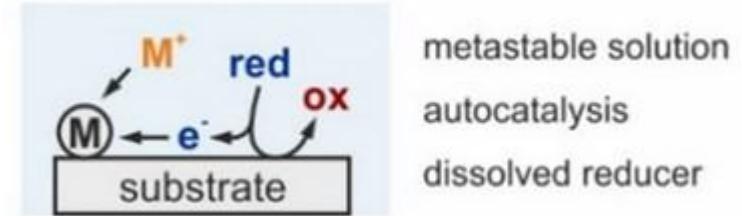


# Epitaxial Growth from liquid solution (no template)

- Deposition from non-aquous Co solution (reduction of metal complex on seed films)
- Epitaxy on **Pt(111)**, **Co(0001)**, **Au(111)**, ... -> dense arrays of Co nanowires
- „Solution Epitaxial Growth“, no mention of electroless plating; yet similar (heterogenous catalyzed reduction with dissolved reducing agent;  
extra: ligands blocking lateral growth – so not conformal coating)



X-Ray diffraction (talk by Ondřej Caha)



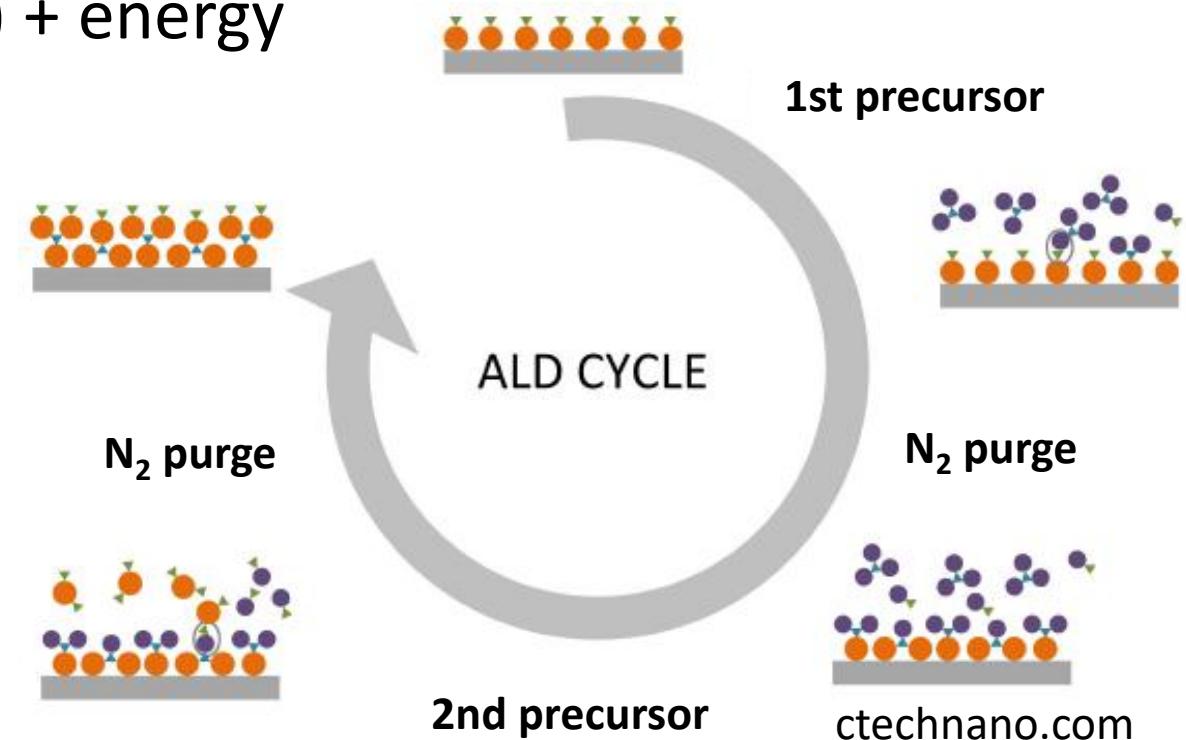
# Atomic layer deposition (ALD)

Started as Atomic layer epitaxy  
*J. Appl. Phys.* **60**, R65–R82 (1986); [Short history](#)

- Special mode of Chemical Vapour Deposition (CVD)
- Sequential self-limiting surface chemical reactions  
precursor 1 + precursor 2 (reactant) + energy

## pros and cons

- surface chemistry-dependent
- slow, coating could be very granular
- + thickness control @ atomic scale
- + conformal coating (uneven surfaces, pores)



ctehnano.com

ALD Review: [George, Chem. Rev. 110, 1, 111–131 \(2010\)](#)

List of materials (oxides, nitrides, metals, ...): [Miikkulainen, J. Appl. Phys. 113, 021301 \(2013\)](#)

Recipes and various info: <https://www.plasma-ald.com/>

# ALD example – Nanotubes in porous template

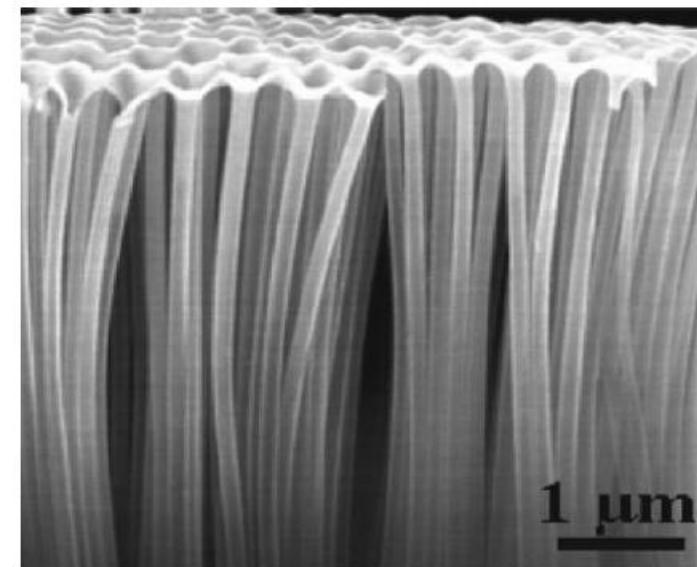
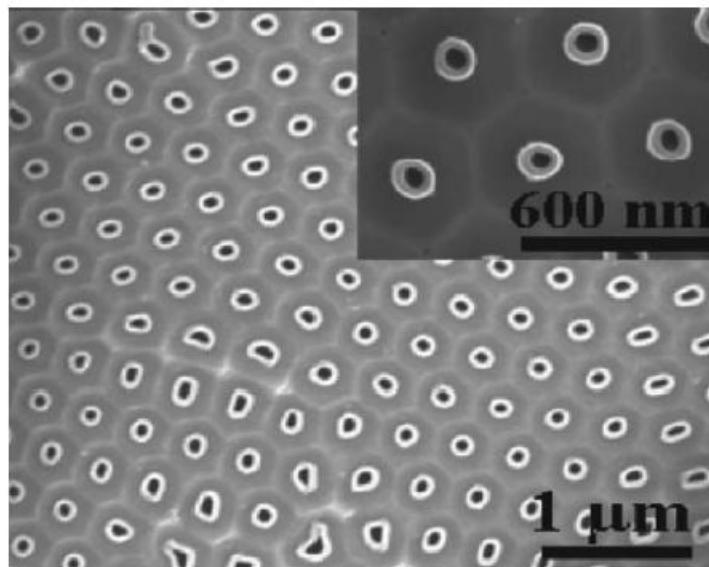
Deposition of (non-ferromagnetic) oxide, reduction to metal later

Example: Ni, Co Nanotubes – *JAP 111, 09J111 (2007)*

Template: pore diameter 35 nm and 160 nm, length 2-50 $\mu$ m

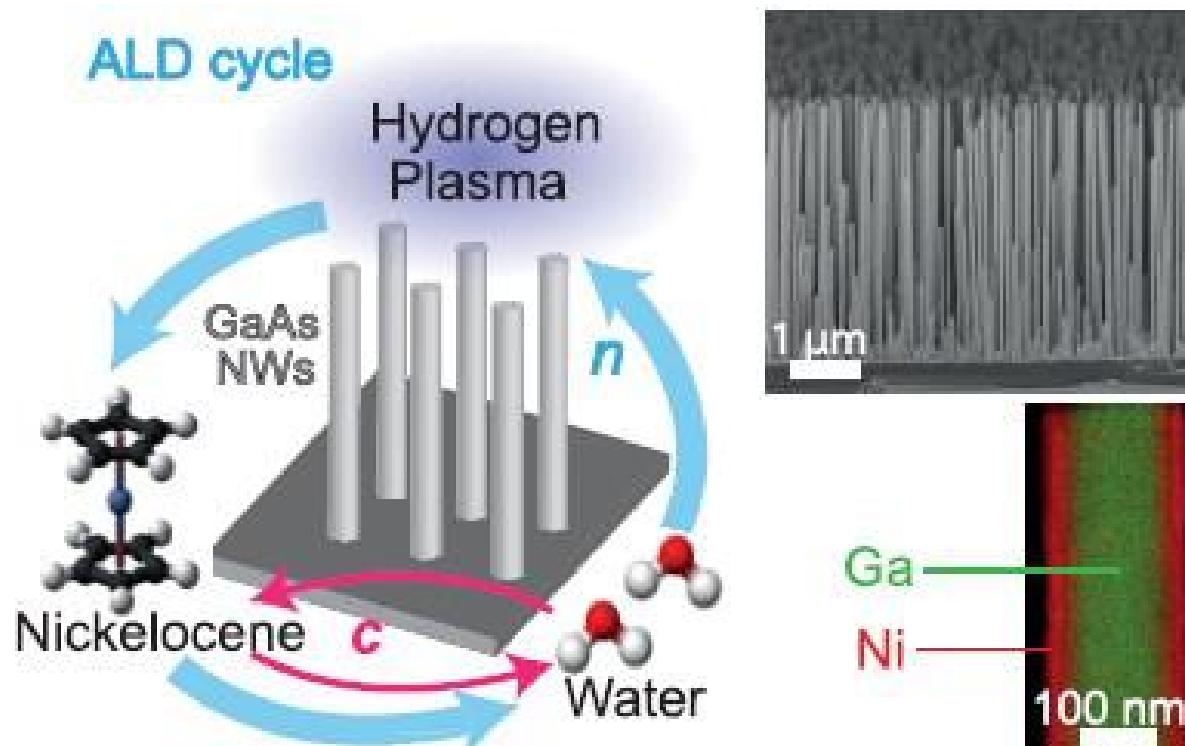
Precursor: nickelocene (NiCp<sub>2</sub>) + H<sub>2</sub>O vapour – gives oxide

Reduction better after ALD – Ar+5 % H<sub>2</sub> (lower grain size)



SEM images: TiO<sub>2</sub>/Ni/TiO<sub>2</sub> tubes. Left: in template (top-view), Right: liberated.

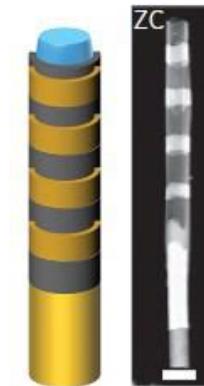
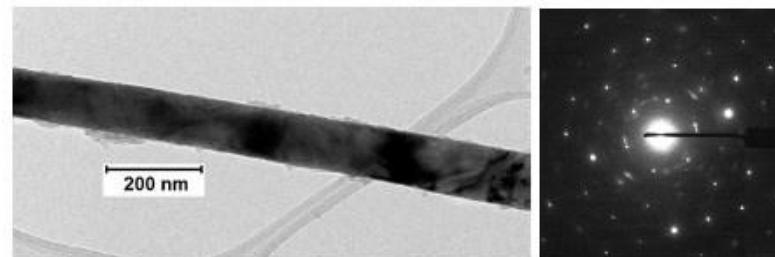
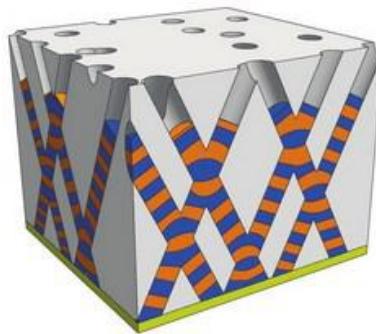
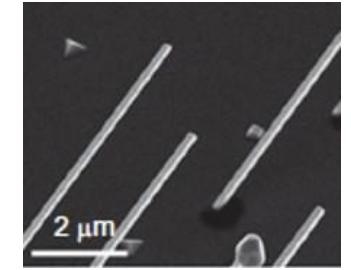
# ALD example – Nanotubes on single-crystalline GaAs nanowires



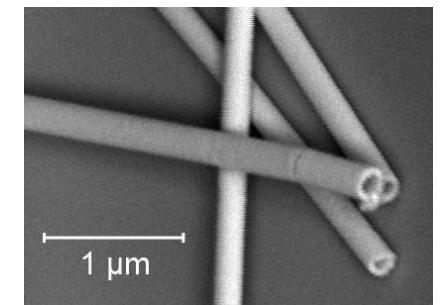
[Giordano, ACS Appl. Mater. Interfaces 12, 40443–40452 \(2020\)](#)

# Summary – Nanowire & nanotube depositions

- **Common epitaxy techniques (vapour depositions):**  
vacuum & temperature; high crystal quality, limited geometry control
- **Electrodeposition in templates (liquid solution / water based)**  
complex structures and geometry, crystal control possible



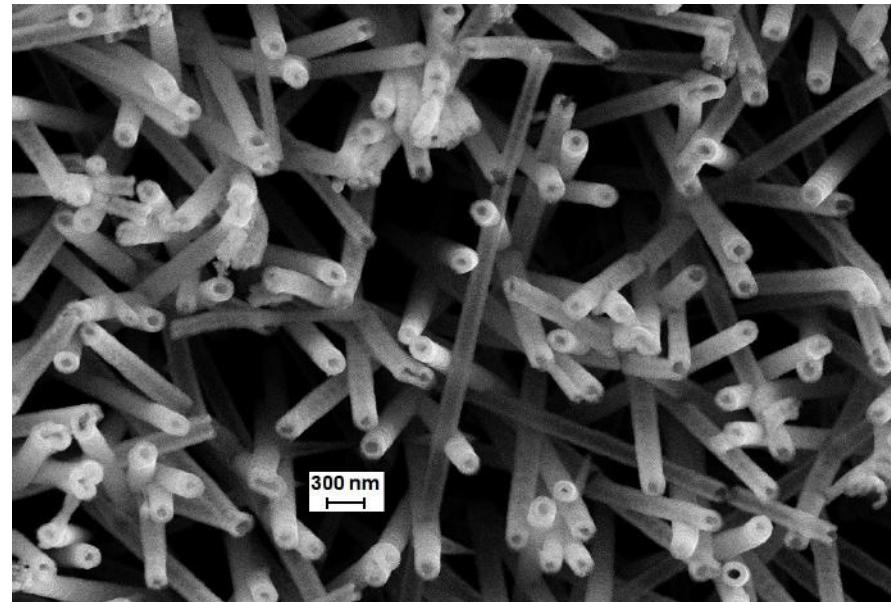
- Nanotubes: **electroless plating, atomic layer deposition**  
conformal coating of complex scaffolds; often nanocrystalline



# Acknowledgement

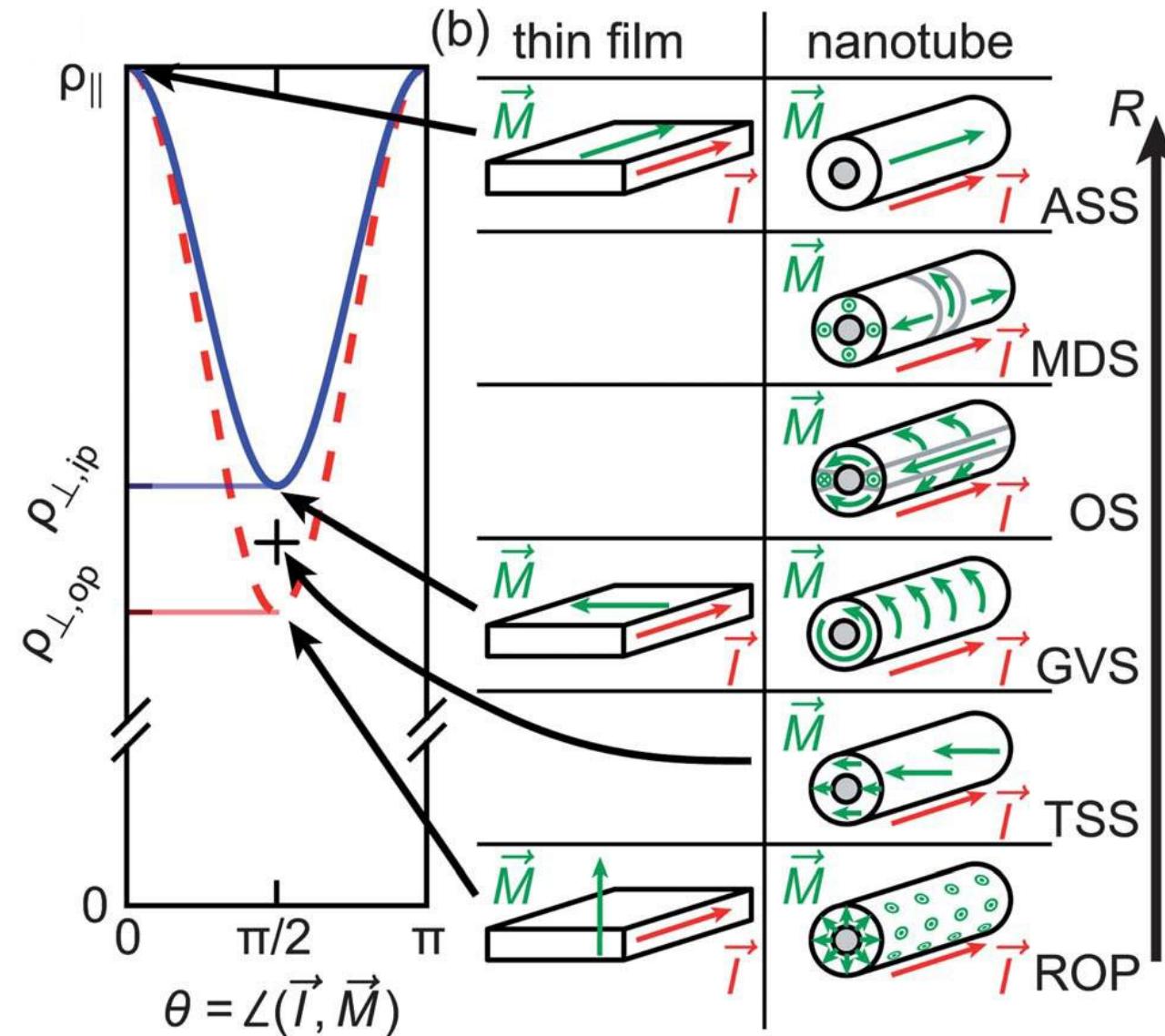
Jon Ander Arregi, Ondřej Wojewoda, Vojtěch Uhlíř

## Questions & Discussion

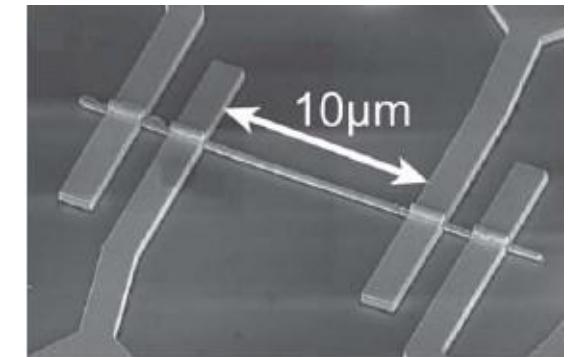
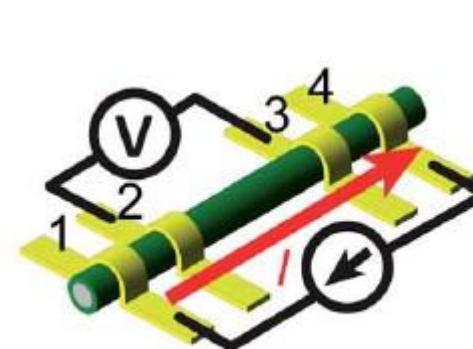


# Additional slides

# Anisotropic Magnetoresistance (AMR)



Resistance depends on angle between magnetization and applied current  
max R:  $\mathbf{M}$ ,  $\mathbf{I}$  parallel  
min R:  $\mathbf{M}$ ,  $\mathbf{I}$  perpendicular  
 $\mathbf{M}$  can be set by external magnetic field



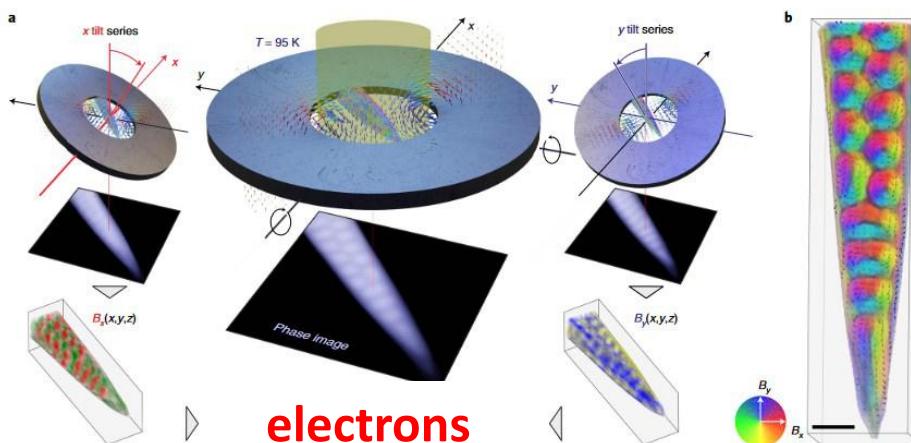
[Rüffer, \*Nanoscale\* 4, 4989 \(2012\)](#)  
Longitudinal resistance, 4 probes

# How to resolve magnetization in 3D?

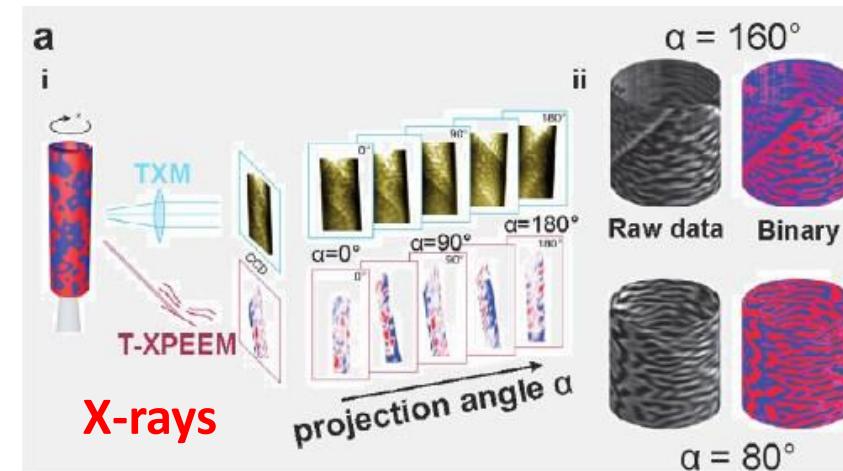
Typical approach - **Tomography using electrons or polarized photons (X-Rays):**

**Electrons - Transmission electron microscopy**, e.g., electron holography

**Polarized photons – synchrotron X-rays**, utilizing X-ray magnetic (circular) dichroism: transmission X-ray microscopy, ptychography, holography (lense-less)



Wolf, *Nat. Nanotechnol.* **17**(3), 250-255 (2022)



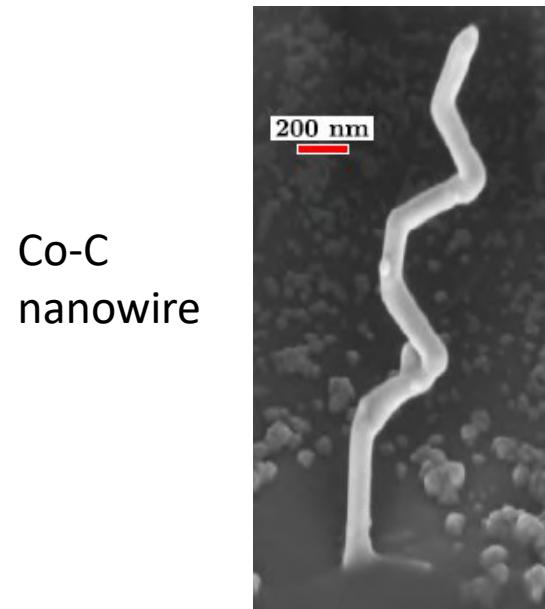
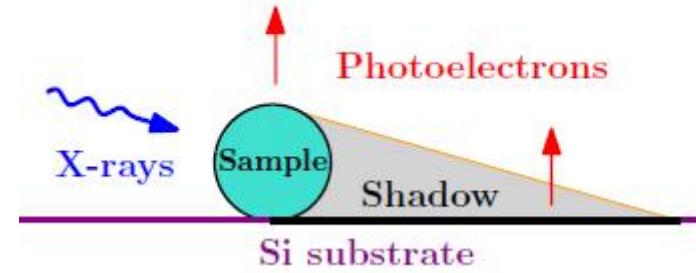
Streubel, *Nat. Commun.* **6**, 7612 (2015)

Review (3D with X-rays): Donnelly, *J. Phys.: Condens. Matter* **32**, 213001 (2020)

# Alternative: The dark side - shadow

## Shadow X-Ray PhotoEmission Electron Microscopy

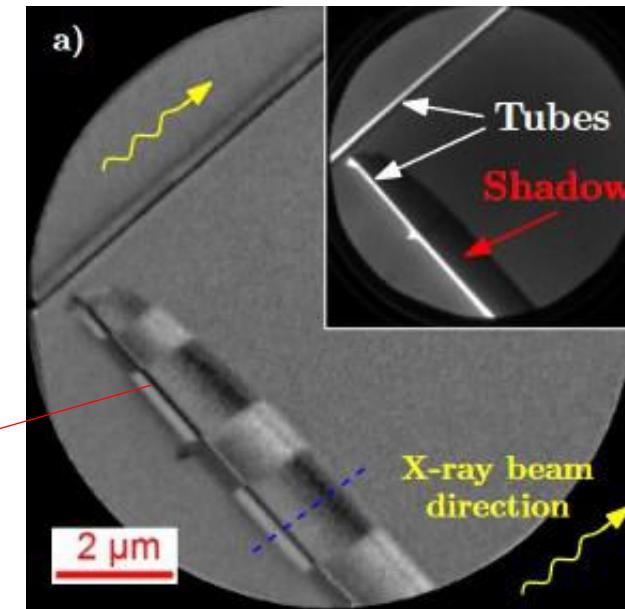
- **X-PEEM**, shadow = transmission info
- **Both surface and volume** info, no tomography  
projection of magnetization to beam direction
- Technique: [Jamet et al., PRB 92, 144428 \(2015\)](#)



Co-C  
nanowire

[Wartelle, Nanotechnology  
29, 045704 \(2018\)](#)

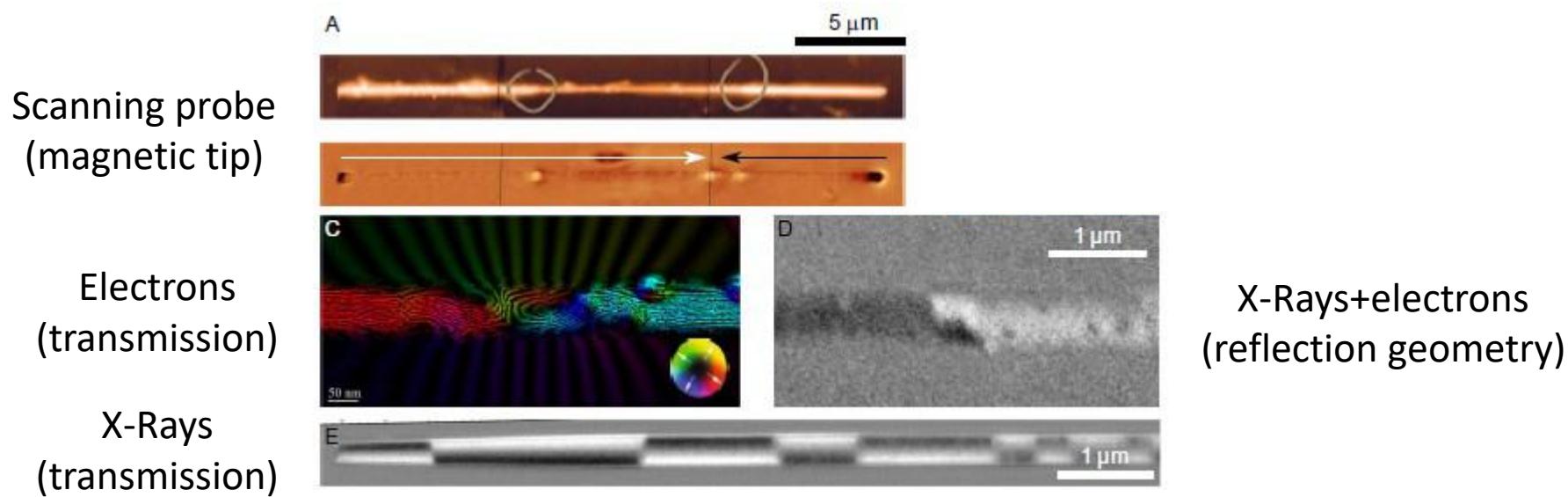
Different  
magnetic  
domains



CoNiB  
nanotubes

[Staňo, SciPost Phys. 5, 038 \(2018\)](#)

# Additional magnetic imaging techniques

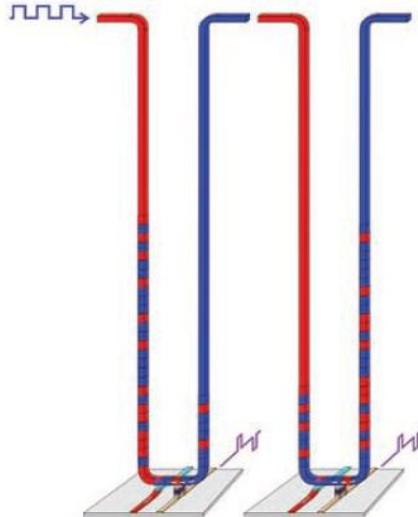


- A) CoNi wire: Atomic force microscopy (top) and Magnetic force microscopy (MFM)
- C) CoNi wire: Electron holography – reconstructed magnetic induction near domain wall
- D) CoNi wire: Shadow XMCD-PEEM with circularly polarized X-Rays near domain wall
- E) CoNiB tube: Scanning transmission X-Ray microscopy with circularly polarized X-Rays, many domains

Staňo & Fruchart, Magnetic nanowires and nanotubes, in *Handbook of magnetic materials* (Vol. 27, pp. 155-267), Elsevier (2018). Also on [arXiv](#).

# Magnetic nanowires - Applications

- Biomed: magnetic resonance imaging, magnetic hyperthermia, catalysis
- Sensors: magnetoresistance sensors; giant magnetoimpedance
- RF signal processing: microwave absorption, filters, phase shifters, ...



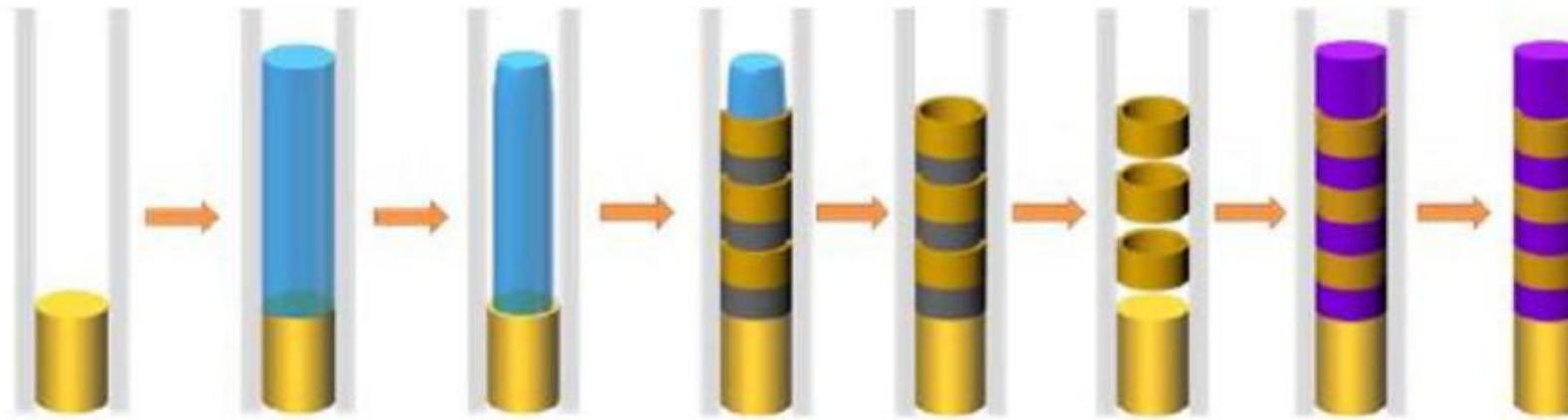
Commercial products available in case of microwires

Staňo & Fruchart, [Magnetic nanowires and nanotubes](#), in *Handbook of magnetic materials* (Vol. 27, pp. 155-267), Elsevier (2018). Also on [arXiv](#).

Magnetic racetrack memory (**concept**)

[Parkin, Science 320\(5873\), 190-194 \(2008\)](#)

# Coaxial lithography – sequence example



Yellow: target material (Au)  
Blue: sacrificial organic core (polyaniline)  
Purple: any conductive material  
Grey: sacrificial material (Ni)

**ED = ElectroDeposition**

Au ED  
polymer ED  
polymer shrinking  
vacuum drying

Ni/Au ED  
polymer dissolution  
acetone

Ni etching  
 $\text{FeCl}_3$

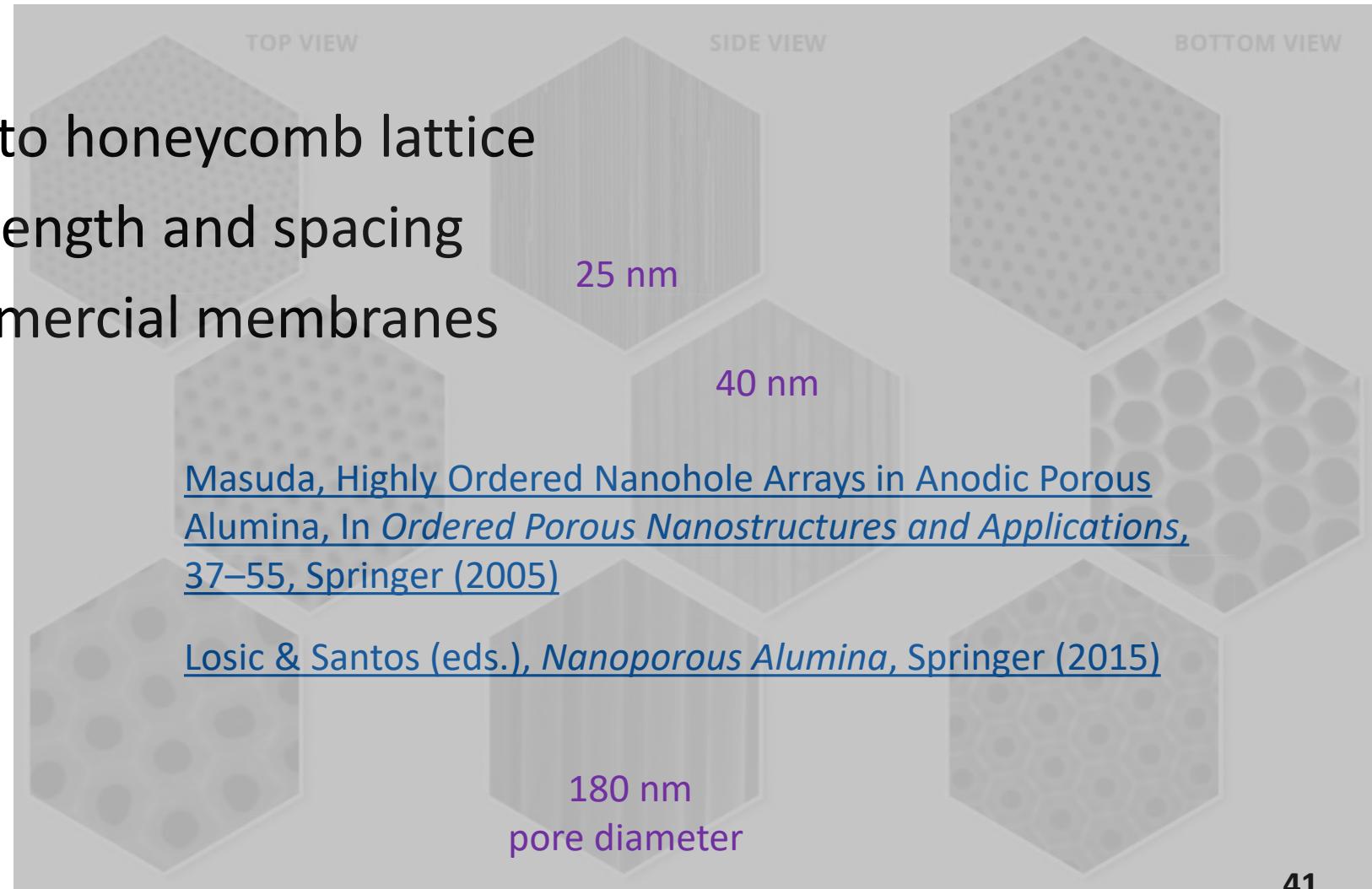
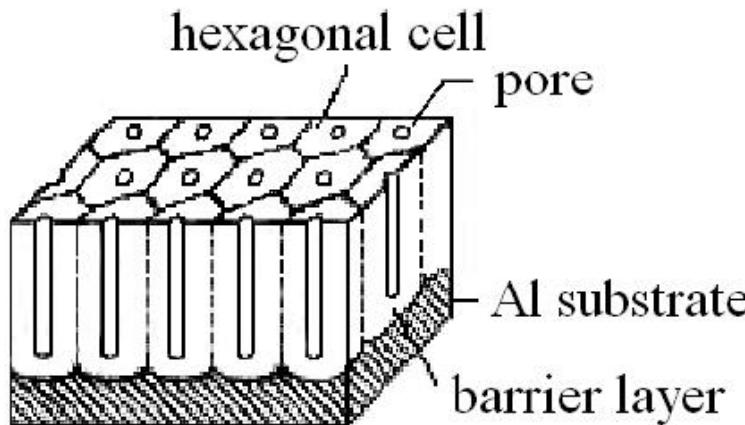
$\text{MnO}_2$  ED  
template dissolution  
 $\text{NaOH}$

Ozel et al., *Nat. Nanotechnol.* **10**(4), 319-324 (2015)

Electrodeposition: Au, Ag, Pd, Ni, Pt, polypyrrole, polyaniline, polythiophene, CdSe, CdS,  $\text{MnO}_2$ , ...

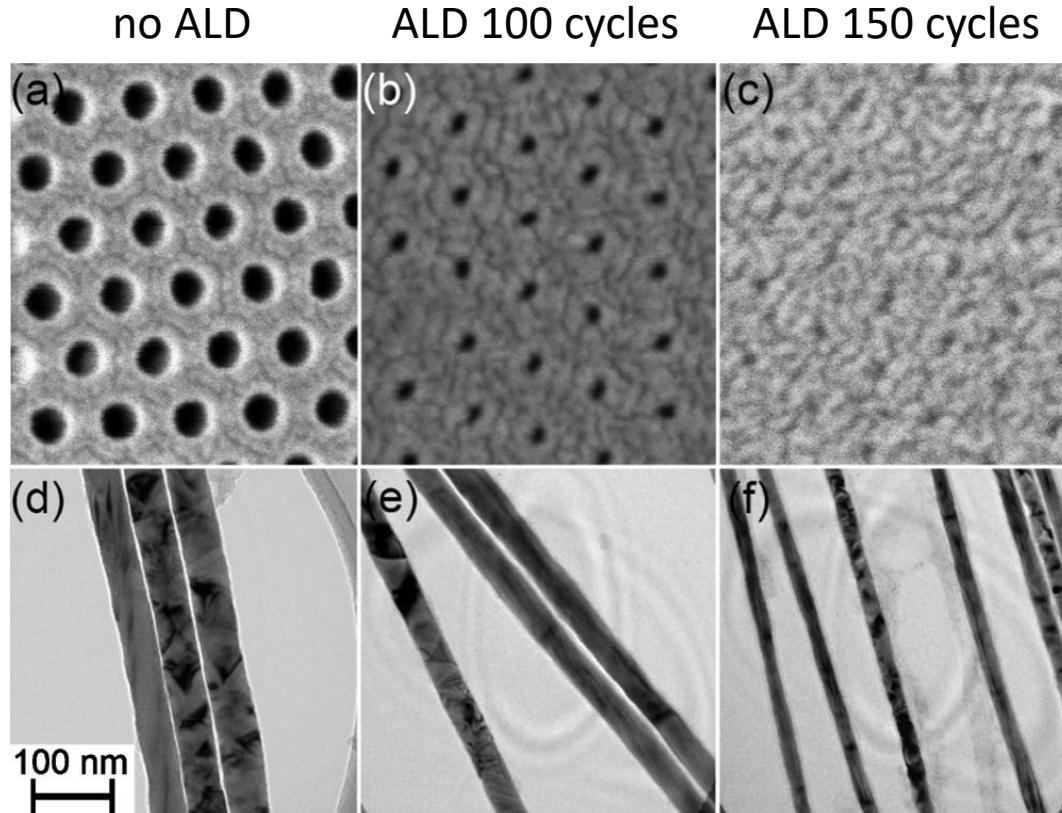
# Nanoporous anodic alumina ( $\text{Al}_2\text{O}_3$ ) templates

- Preparation: Electrochemical oxidation of aluminium in acidic solutions (electrolytes)
- Self-ordering of pores into honeycomb lattice
- Tunable pore diameter, length and spacing
- Both lab-made and commercial membranes



# Nanoporous alumina – pore tuning

- Fine adjustment of pore diameter by chemical etching (wider pores) or **atomic layer deposition (ALD)** of  $\text{Al}_2\text{O}_3$  (narrower pores)



**Nanoporous templates** with pore diameter reduction by atomic alyer deposition (pore walls covered with extra  $\text{Al}_2\text{O}_3$ )

**Ni nanowires** prepared in the modified templates  
(transmission electron microscopy after dissolving the template)

# Elephants (Fabrication methods)



ChatGPT 4o image

Top-down elephant  
from stone block

- Removing material



ChatGPT 4o image

Bottom-up elephant  
from clay pieces

+ Adding material

Practical realization – combination  
(adding+removing material)



Bottom-up elephant + scaffold for trunk



Bottom-up elephant (done)

# Electrodeposition: Standard reduction potentials

Reaction	Standard potential $E^0$
$\text{H}_2\text{O} + \text{e}^- \rightleftharpoons \frac{1}{2}\text{H}_2(\text{g}) + \text{OH}^-$	-0.828 V
$\text{Co}^{2+} + 2\text{e}^- \rightleftharpoons \text{Co}(\text{s})$	-0.277 V
$\text{Ni}^{2+} + 2\text{e}^- \rightleftharpoons \text{Ni}(\text{s})$	-0.257 V
$2\text{H}^+ + 2\text{e}^- \rightleftharpoons \text{H}_2(\text{g})$	0 V (reference – standard hydrogen electrode - SHE)
$\text{Cu}^{2+} + 2\text{e}^- \rightleftharpoons \text{Cu}(\text{s})$	+0.342 V
$\text{Cu}^+ + \text{e}^- \rightleftharpoons \text{Cu}(\text{s})$	+0.520 V
$\text{Ag}^+ + \text{e}^- \rightleftharpoons \text{Ag}(\text{s})$	+0.800 V

(s) – solid, (g) - gas

More positive potential – easier to reduce

Deposition possible for  $E \leq E^0$  (thermodynamics)

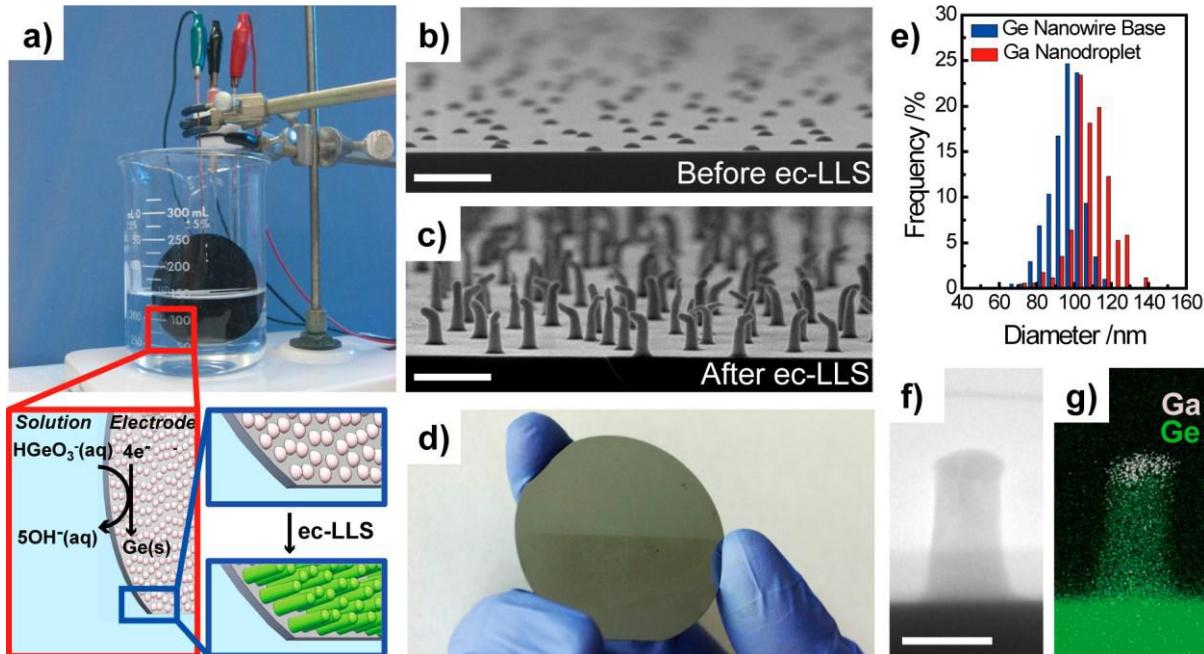
Rate control via concentration (kinetics)

Example – electrolyte with both  $\text{Co}^{2+}$  and  $\text{Cu}^{2+}$

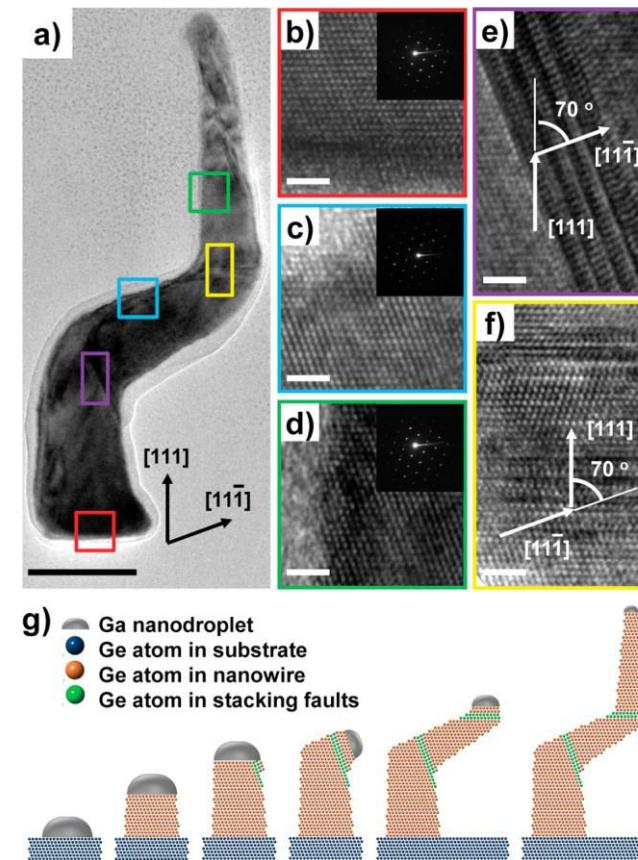
@ +0.1 V vs SHE: only Cu deposited

@ -0.4 V vs SHE: both Co and Cu deposited; low  $\text{Cu}^{2+}$  concentration is used to have negligible Cu deposition

# Epitaxial electrodeposition of Ge nanowires (curiosity)



[Fahrenkrug, \*Nano Lett.\* \*\*14\*\*, 2, 847–852 \(2014\)](#)



# Electroless plating – What can be achieved?

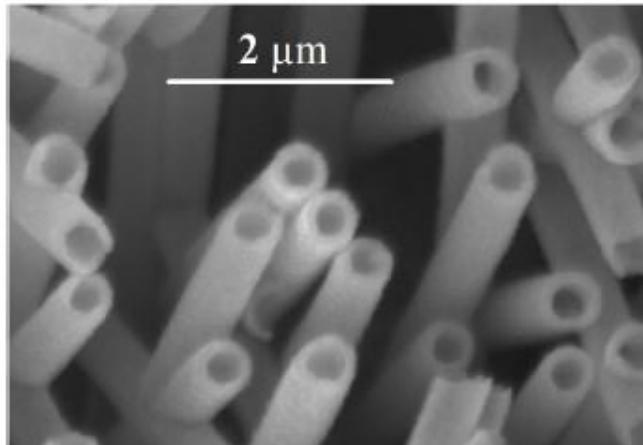
Examples from the literature:

U Limerick, Prof. Rhen:

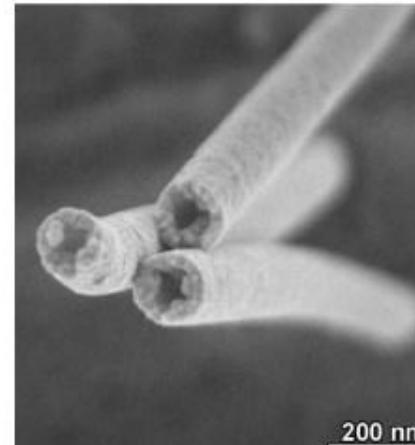
- NiFeB, CoB, NiCuB, CoNiFeB [*Phys. Procedia* **75**, 1158-1166 (2015)]

TU Darmstadt, Prof. Ensinger:

- Pd, Rh, Pt, Au, Ag, Cu, Ni [*ChemPlusChem* **80**, 1448-1456 (2015)]
- CoB, CoNiB, NiFeB [*SciPost Phys.* **5**, 038 (2018)]



NiFeB [U Limerick]

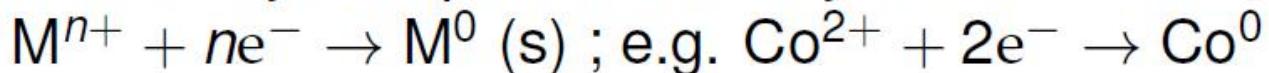


Au [TU Darmstadt] 'tube' from Arrakis [Dune 2021]



# Electroless plating – How it works

Autocatalytic deposition: catalyzed reduction of metallic ions

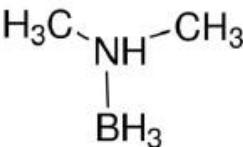


Ingredients:

- source of metal to be deposited ( $CoSO_4 + H_2O$ ), additives



- source of electrons (DMAB, Na hypophosphite)



- catalyst (e.g., Pd, later Co itself  $\rightarrow$  autocatalysis)



- energy (thermal energy)

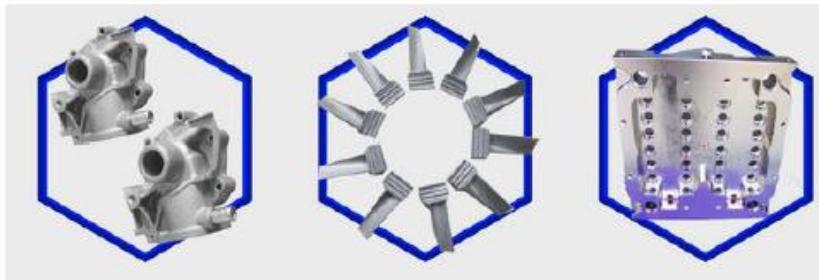
Additional element in the deposit: B, P, N (from the reducing agent)

# Electroless plating: ±, industrial applications

- + **conformal uniform coating** (uneven surfaces, complex shapes)
- + **low cost** (simple 'beaker chemistry')
- + **low processing temperature** (room temperature or < 100 °C)
  - \* variety of materials, **variety of substrates** (inc. non-conductive)
  - \* growth rate spanning 1-100 nm/min (up to 10<sup>1</sup> microns/h)
  - **less precise thickness control** (compared to ALD)
  - **challenge: getting continuous < 10 nm metallic layers**
  - **plating solution – limited lifetime, complex composition**

Book: [Zhang, Amorphous and Nano Alloys Electroless Depositions, Elsevier \(2015\)](#)

Review: [Electroless plating for semiconductor and polymer micro-systems, Microelectron. Eng. 132, 35-45 \(2015\)](#)



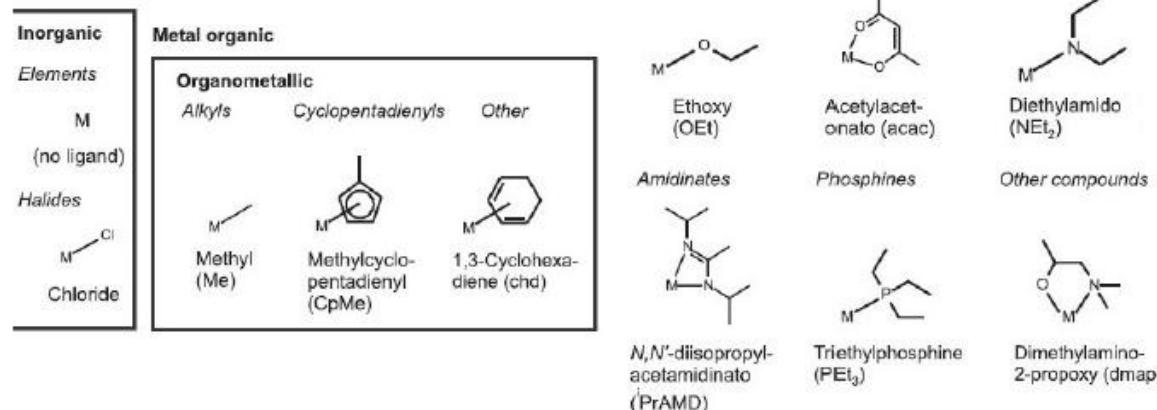
<http://www.silchrome.co.uk/>

- **Industry:** automotive, oil & chemistry, electronics, aerospace, ...
- **corrosion and wear protection**, conductive paths (seed layers), shielding
- electroless **Ni-P**, Cu, composites

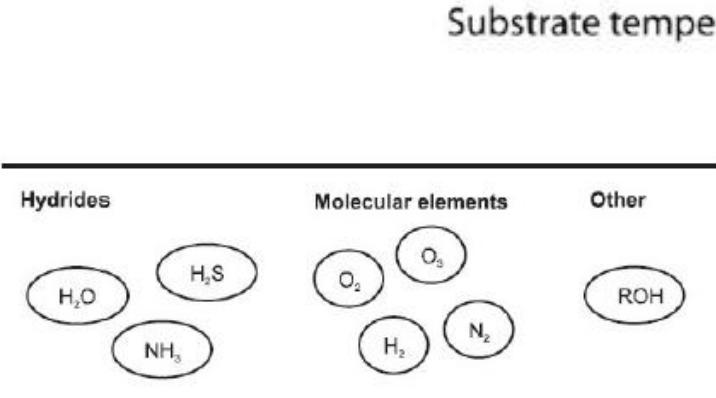
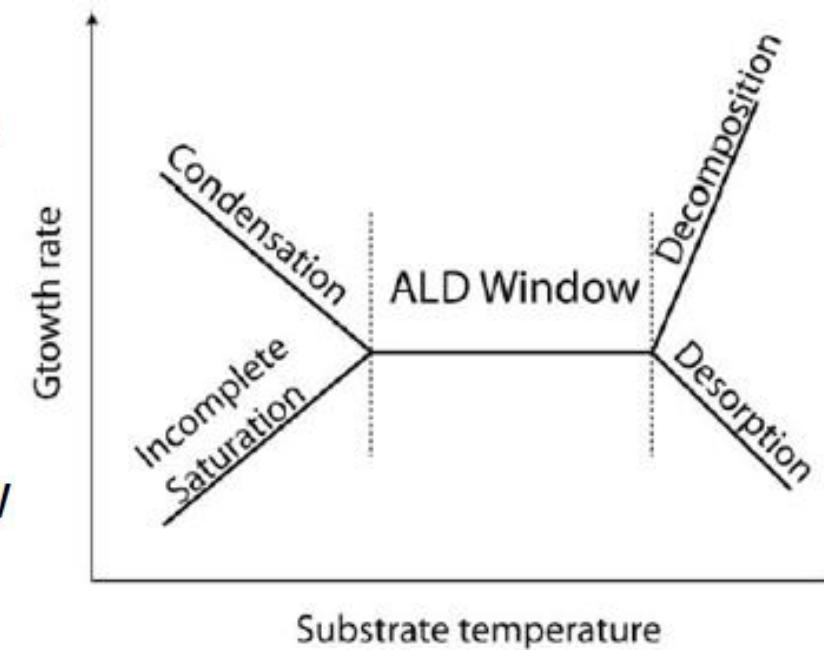
# ALD cooking: Recipe and ingredients

ALD deposition – what is needed

- **vessel**: reactor (rough vacuum, temperature control, gas inlets)
- **ingredients**: precursors and **reactants**
- **energy**: temperature and/or plasma
- **recipe** (process parameters: how much, how long, ...)



(a) precursors – mostly metallo-organics



Miikkulainen et al., *JAP* **113**, 021301 (2013)

(b) reactants